

FIG. 1

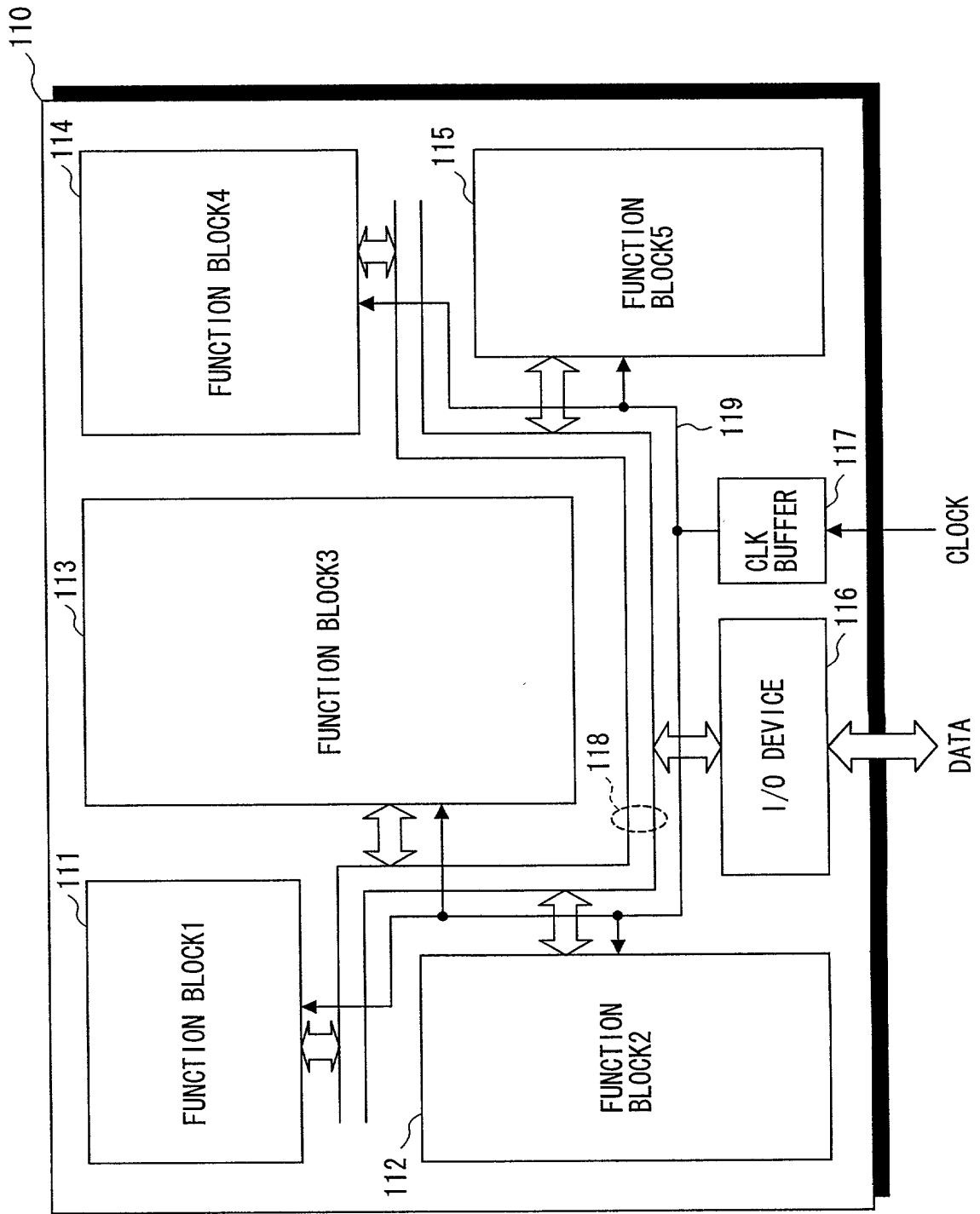


FIG. 3

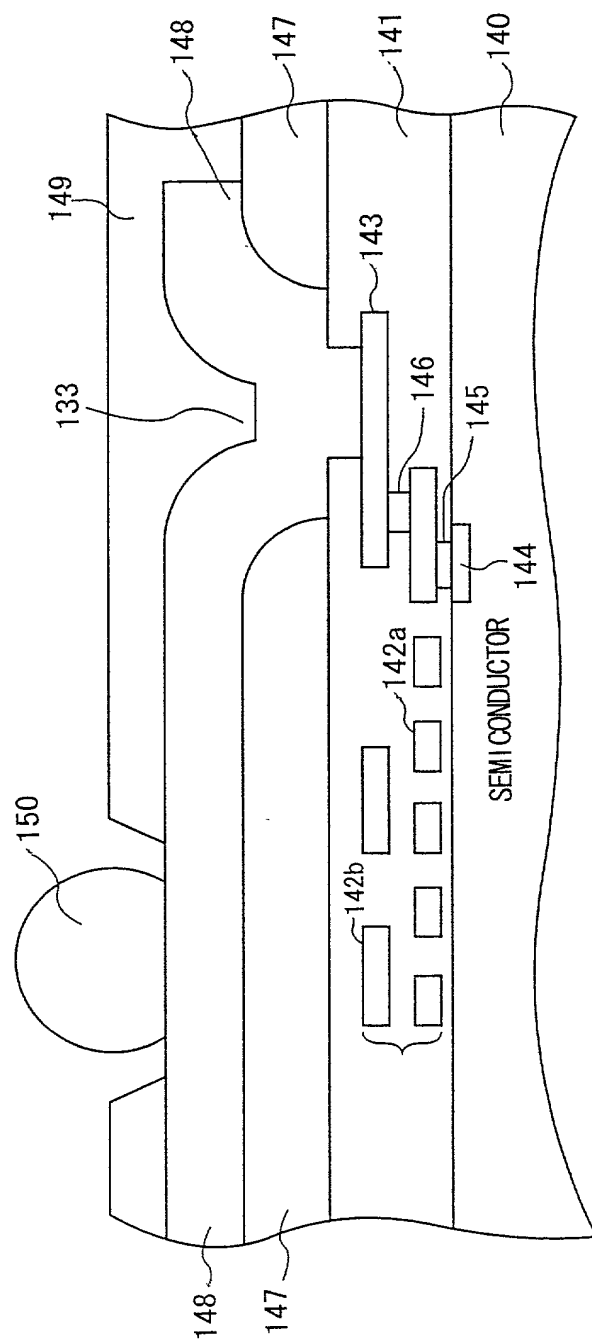


FIG. 4

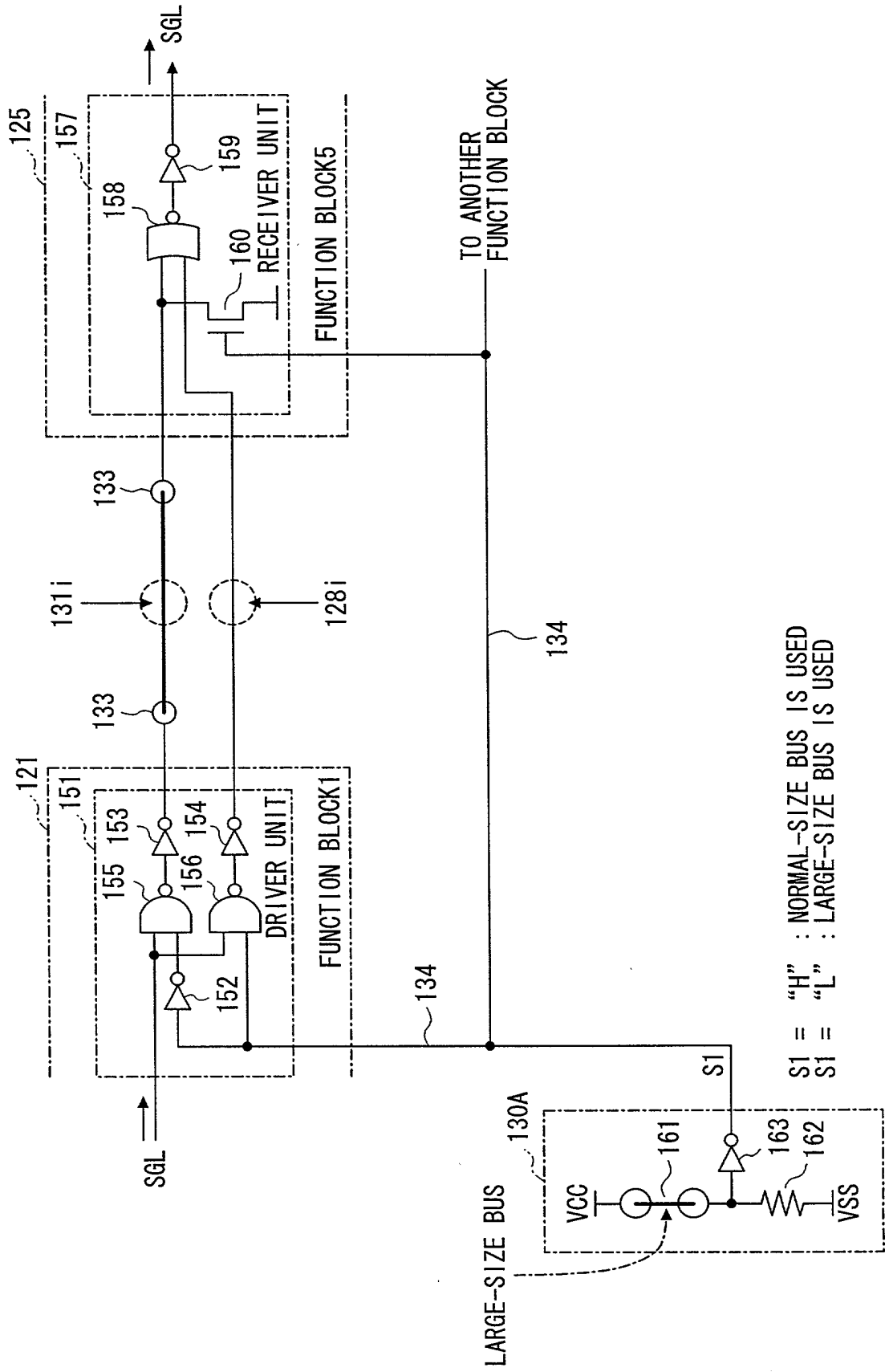


FIG. 5

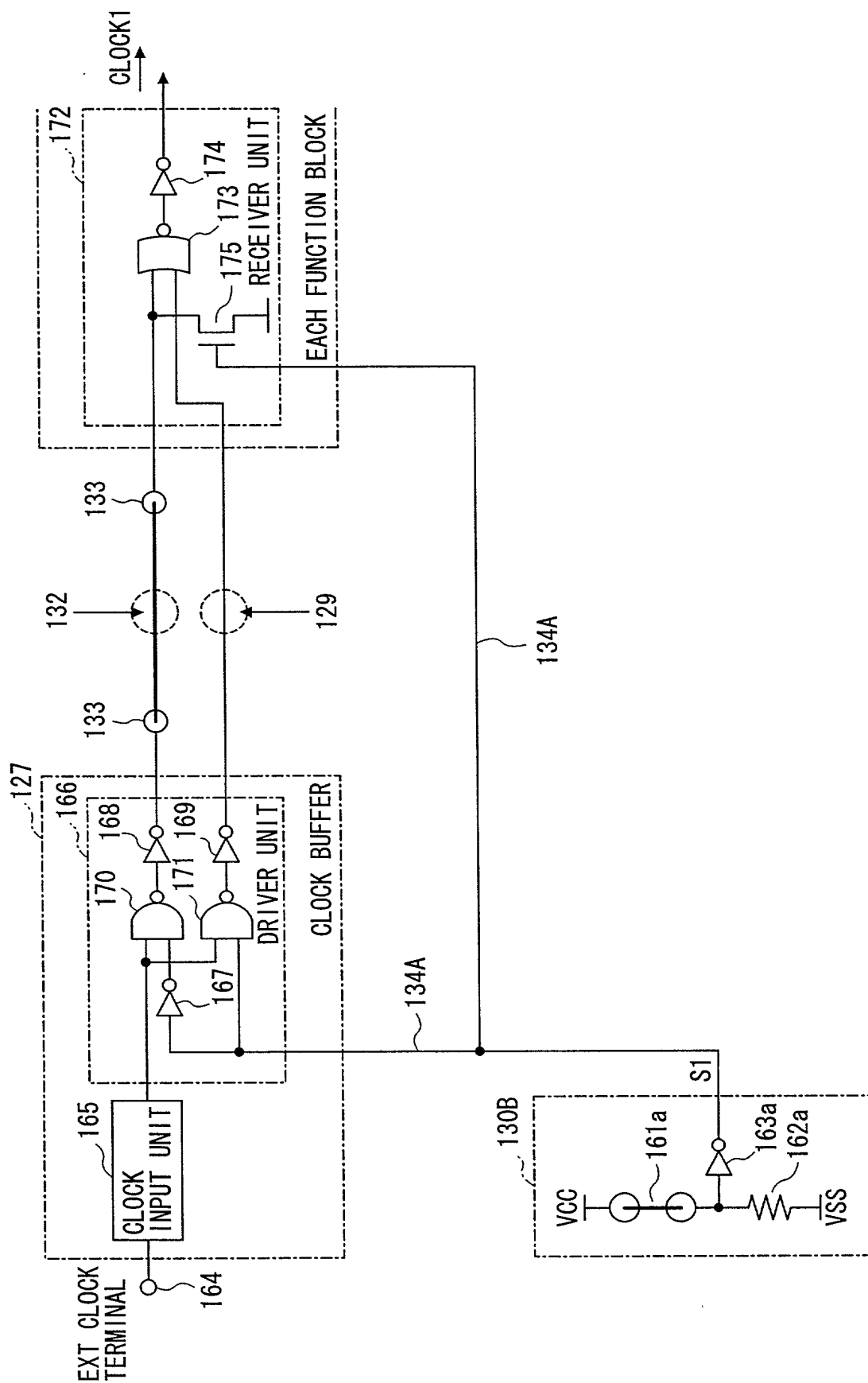


FIG. 6

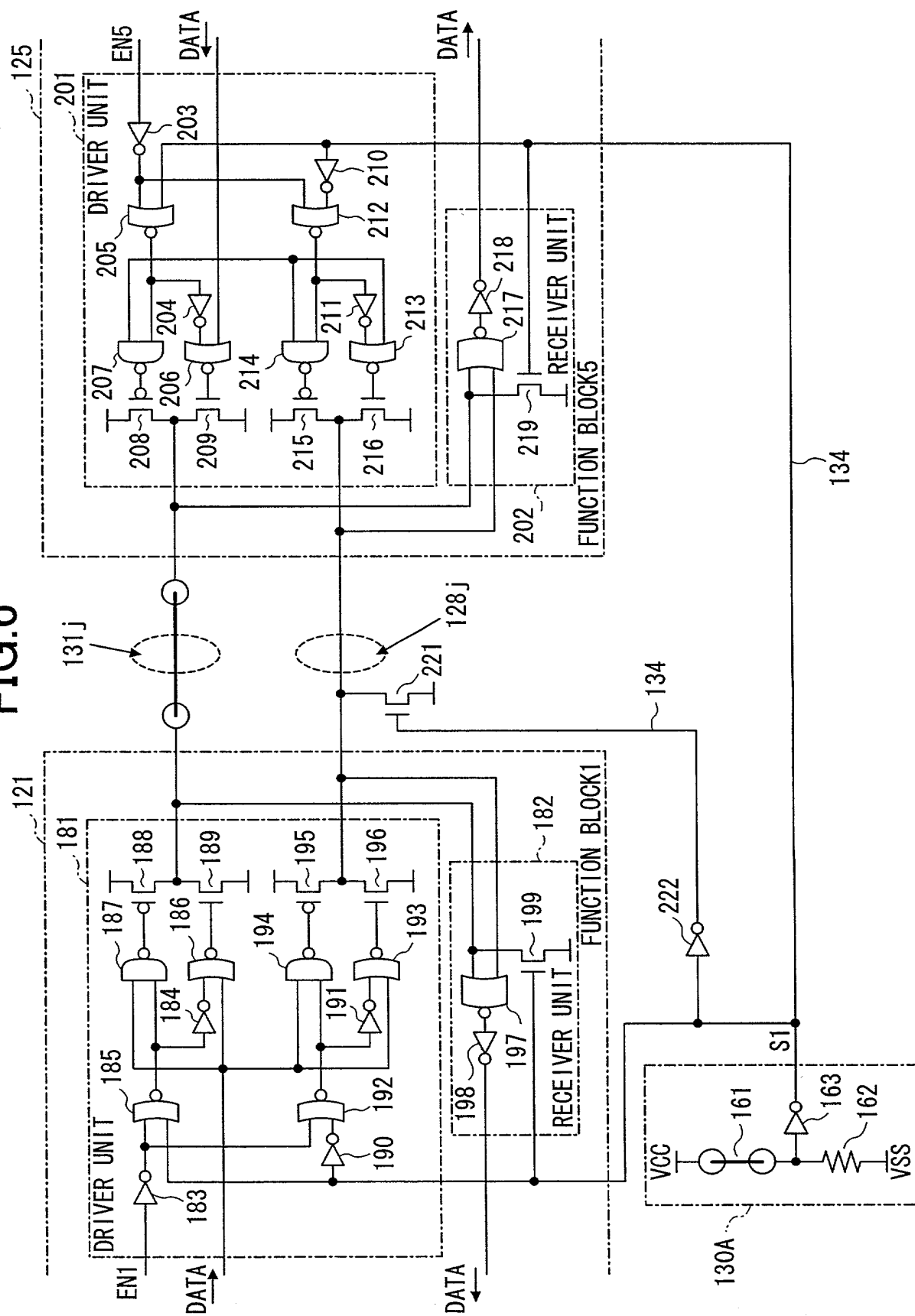


FIG.7A

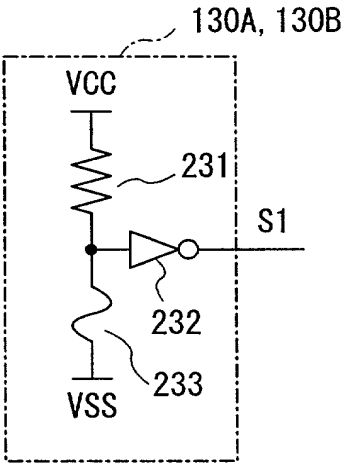


FIG.7B

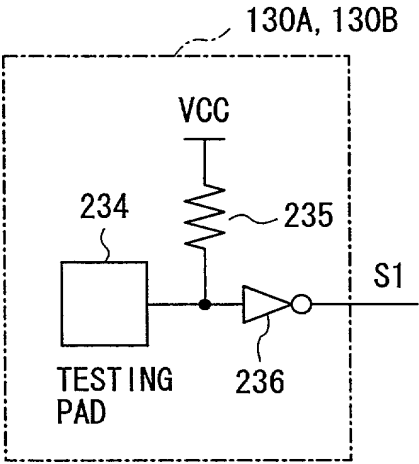


FIG.7C

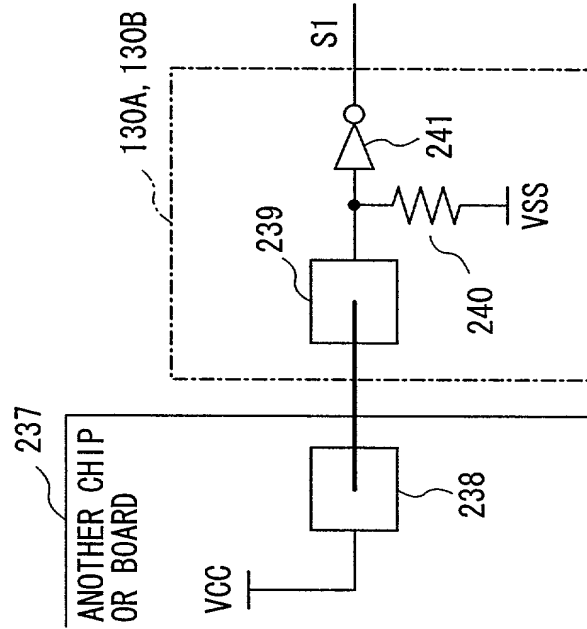


FIG.7D

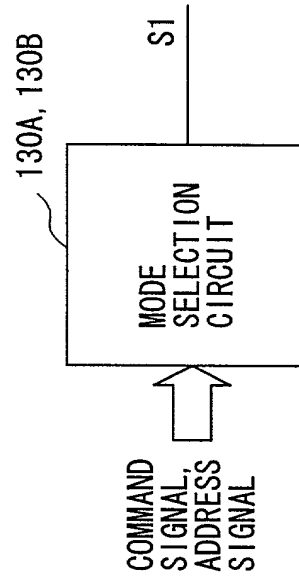
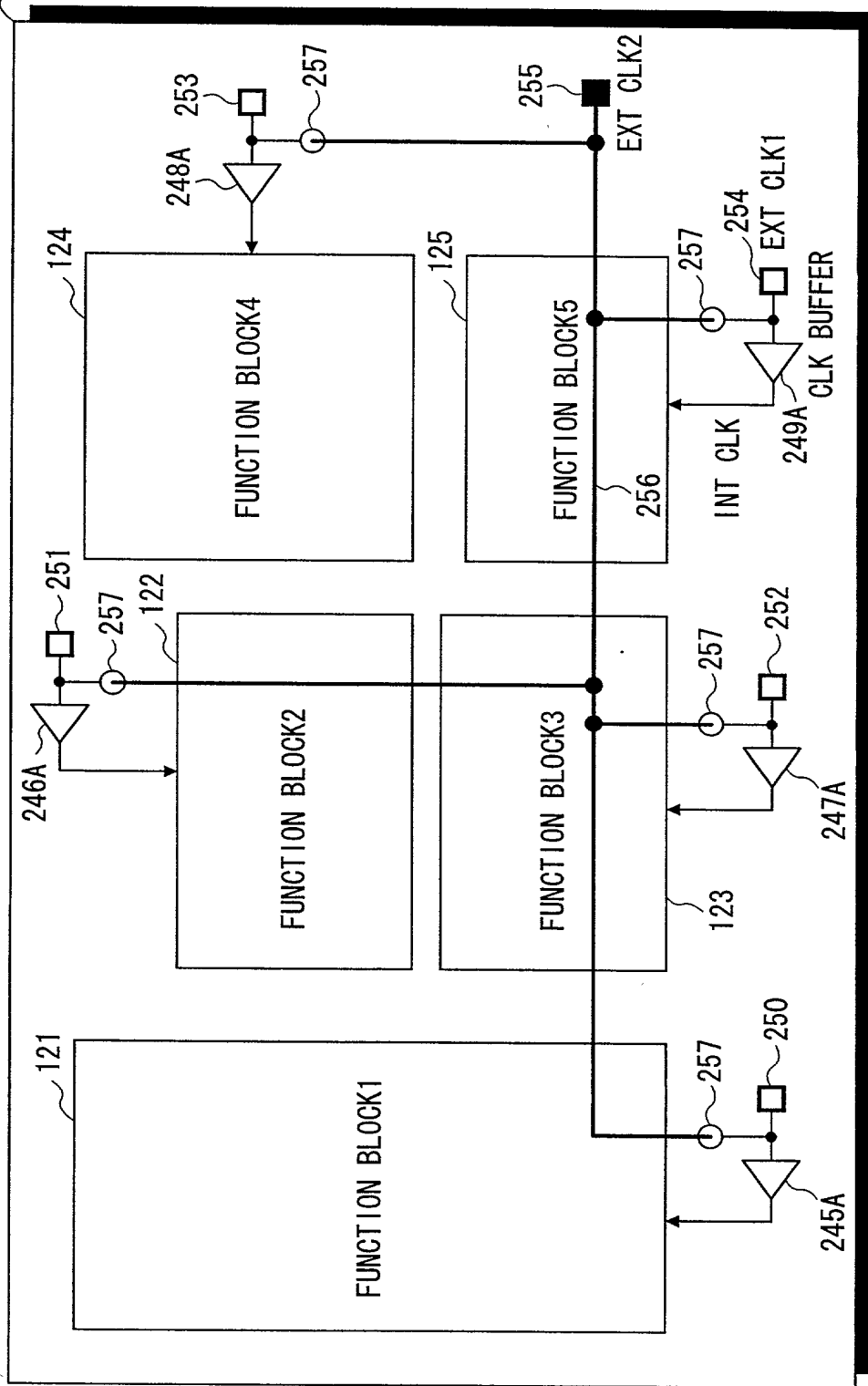


FIG.9

100B



— LARGE-SIZE BUS CONNECTION

- EXT PAD1: FORMED IN LAYER ON NORMAL BUS
- EXT PAD2: FORMED IN LAYER OF LARGE-SIZE BUS
- CONTACT OF LARGE-SIZE BUS AND CIRCUIT

FIG. 10

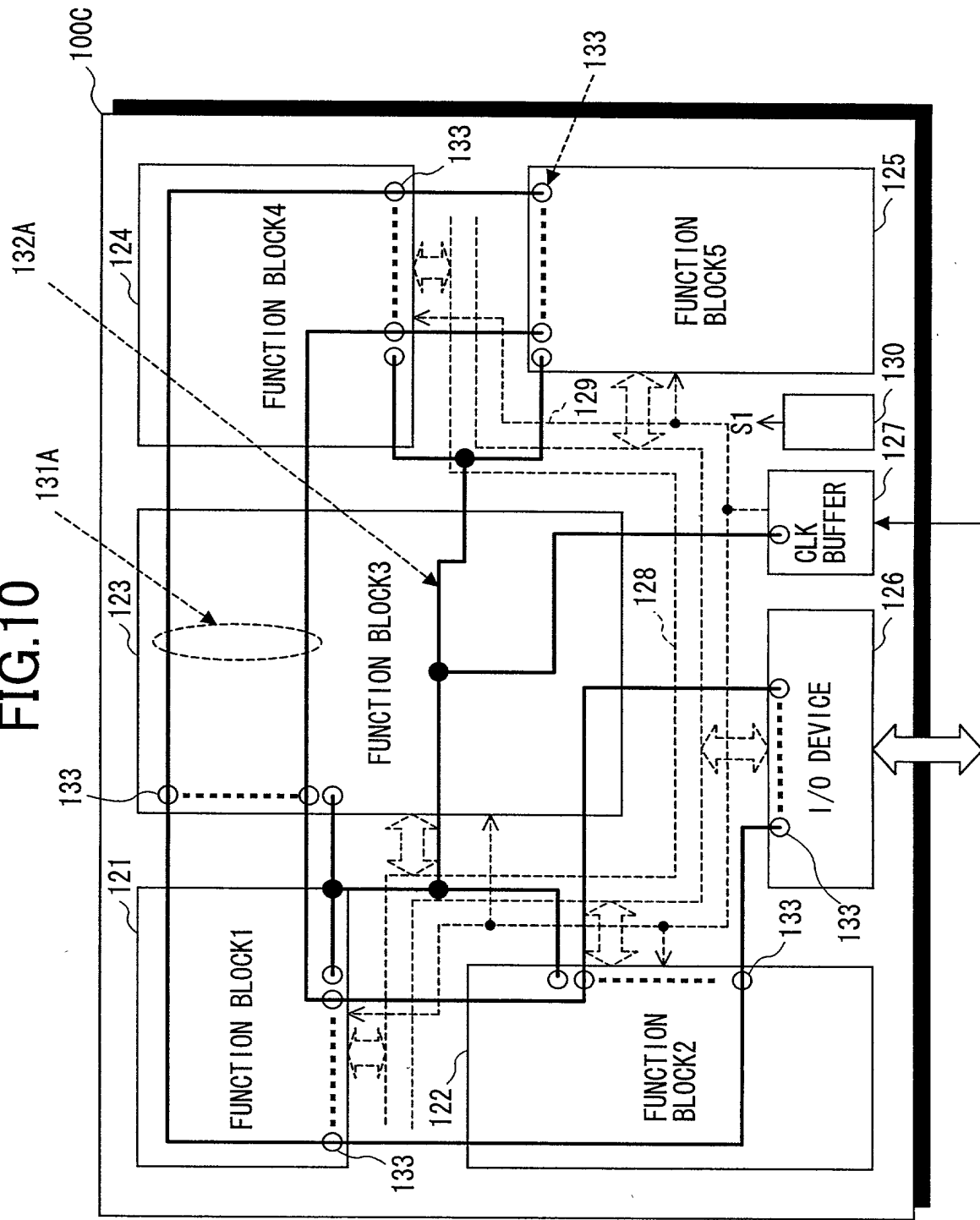
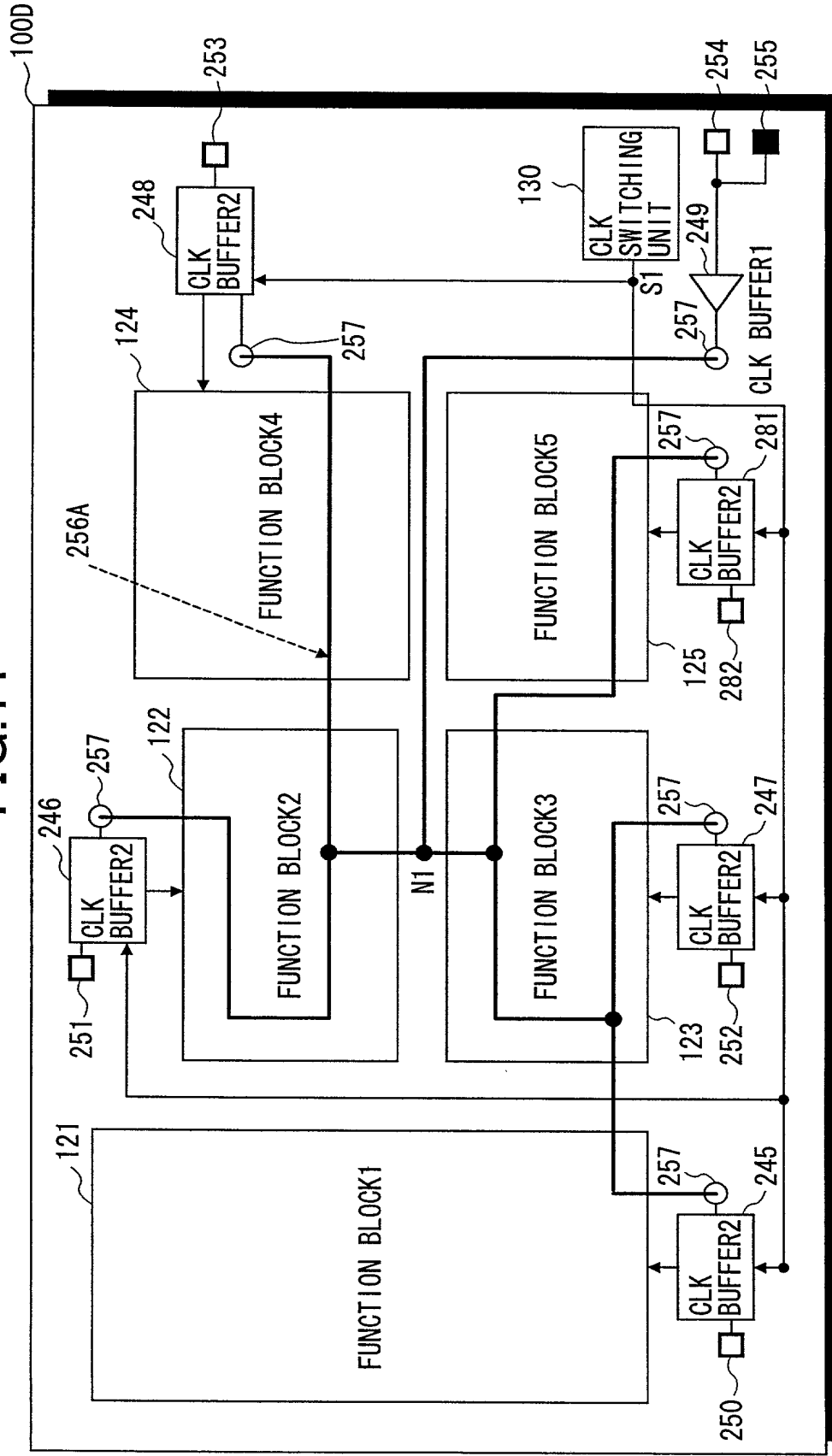


FIG. 11



— LARGE-SIZE BUS CONNECTION

□ EXT PAD1: FORMED IN LAYER ON NORMAL BUS

■ EXT PAD2: FORMED IN LAYER OF LARGE-SIZE BUS

○ CONTACT OF LARGE-SIZE BUS AND CIRCUIT

FIG.12

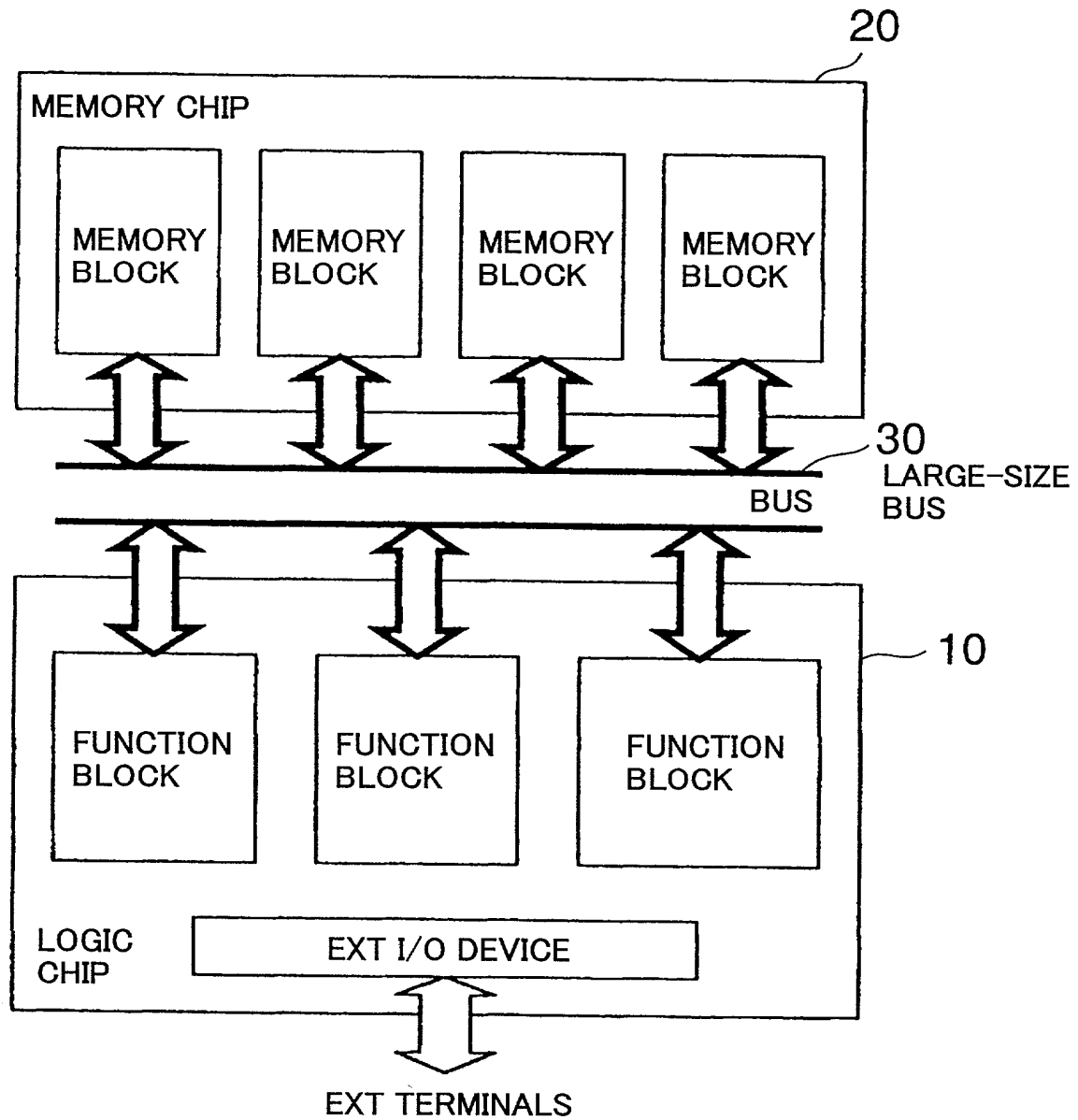


FIG. 13

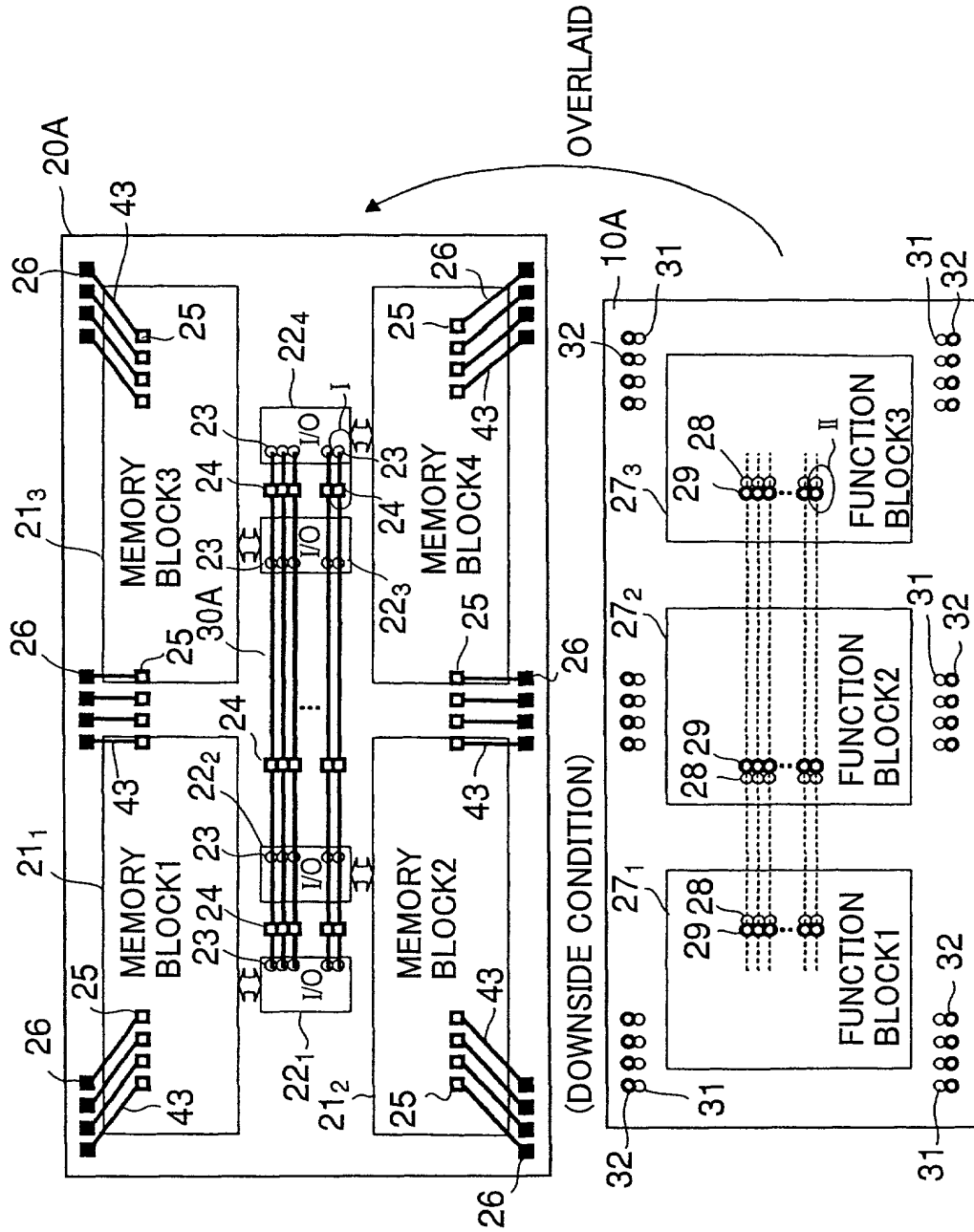


FIG. 14

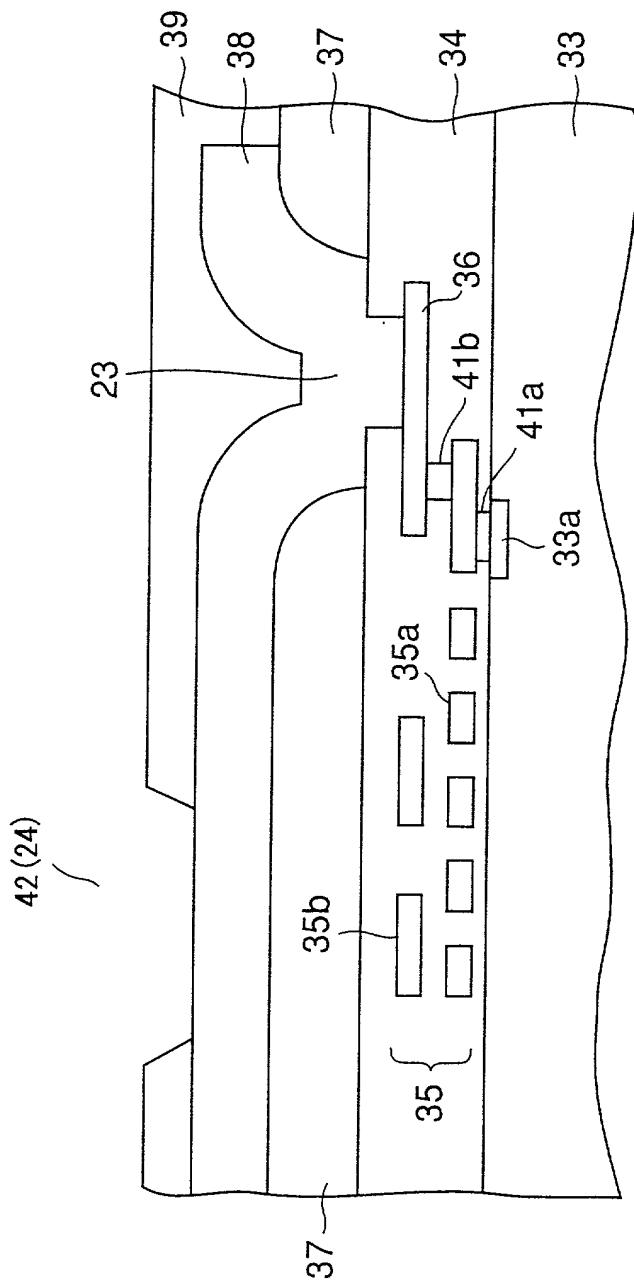


FIG. 15

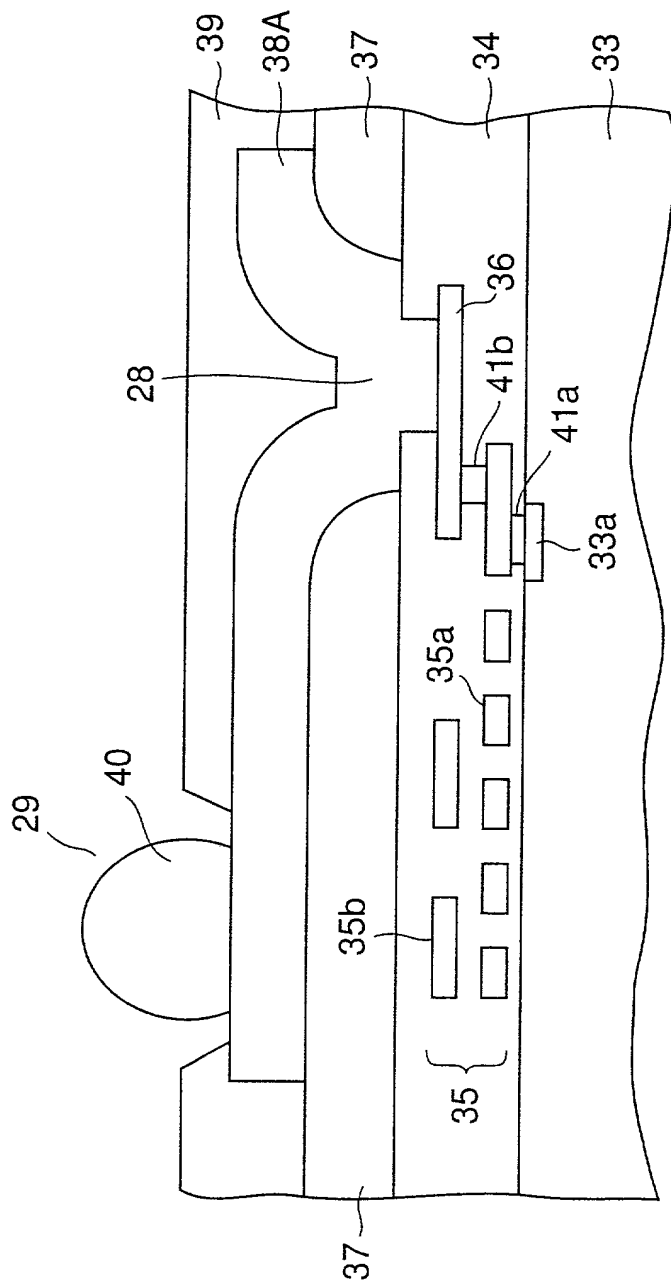


FIG. 16

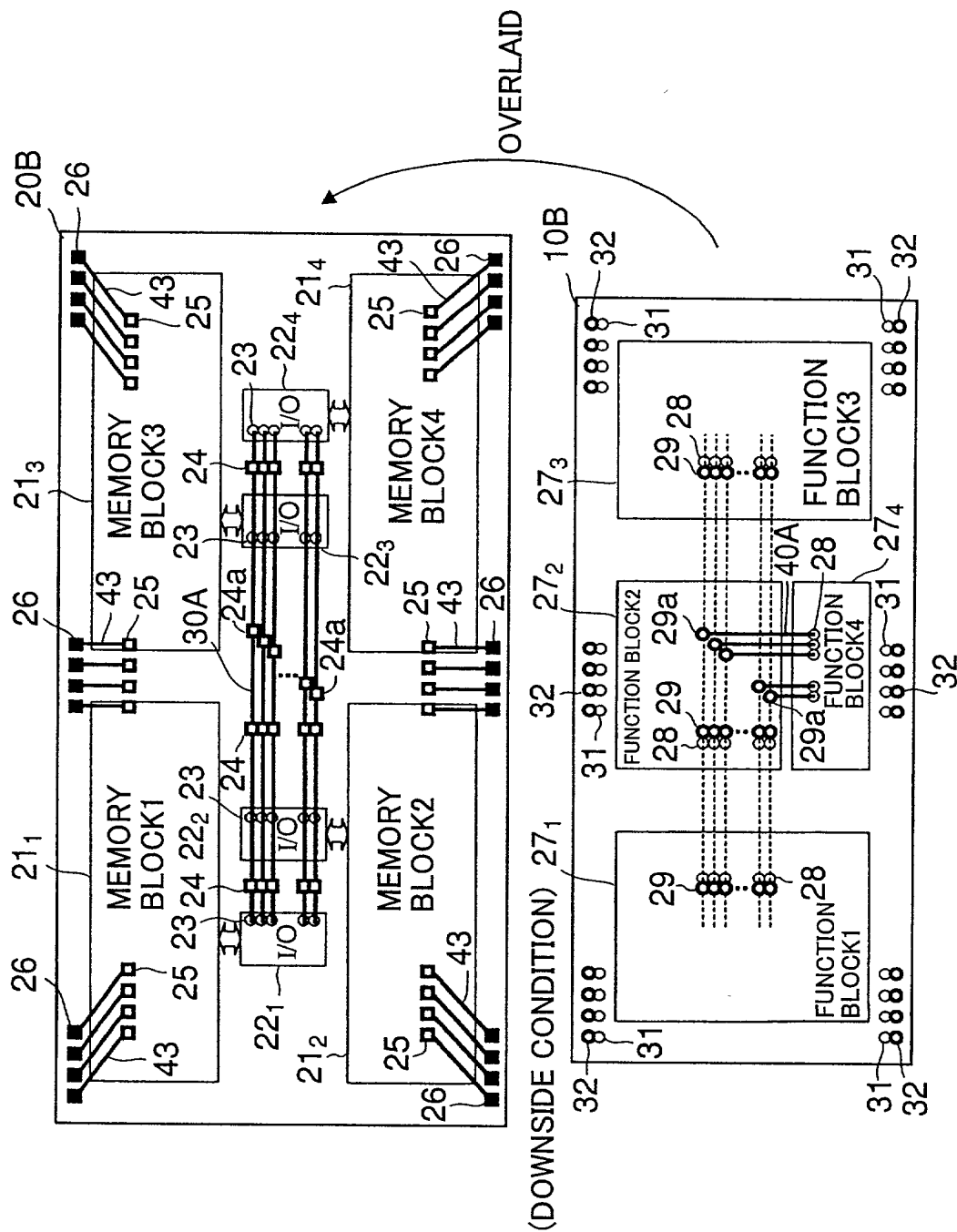


FIG. 17

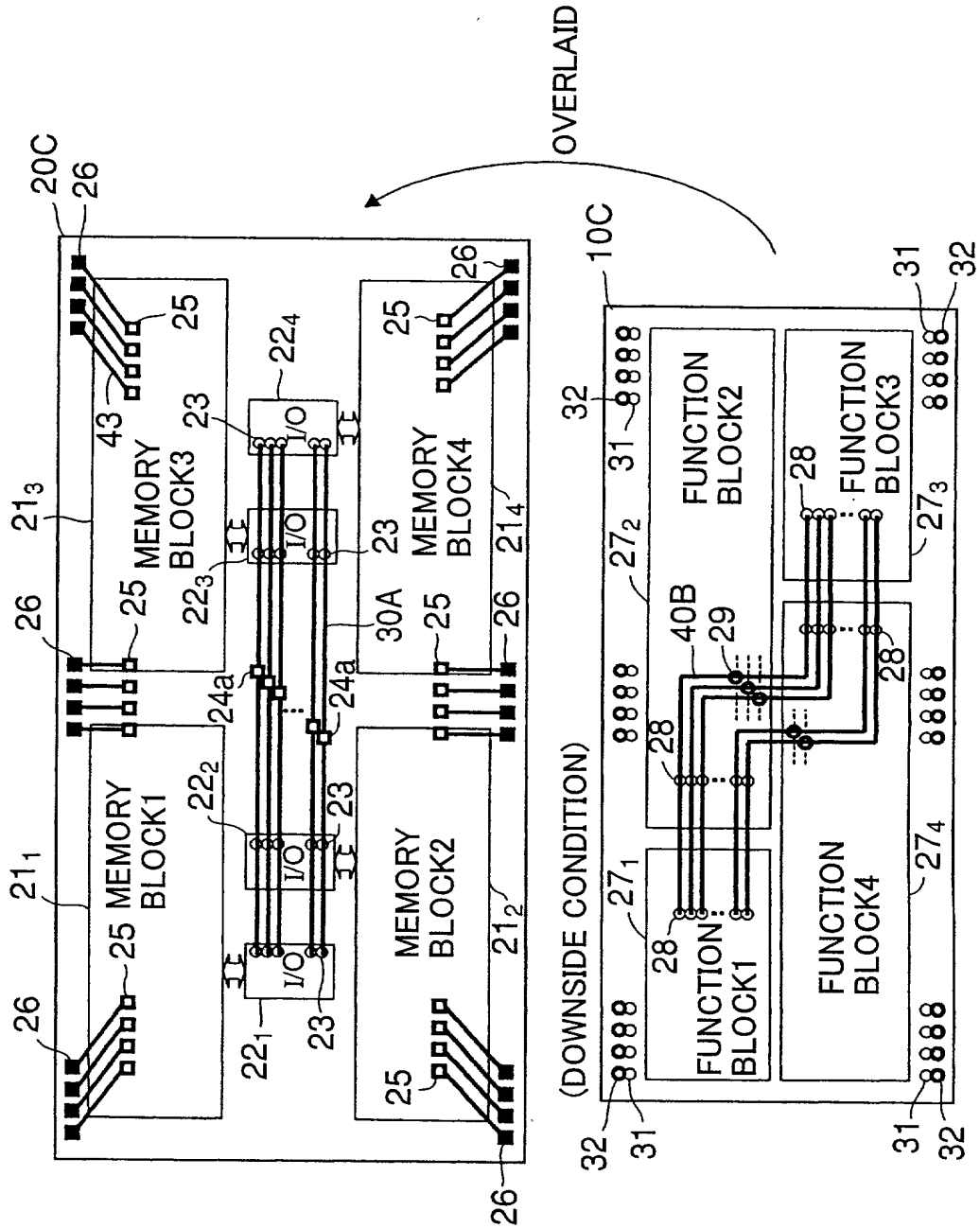


FIG.18

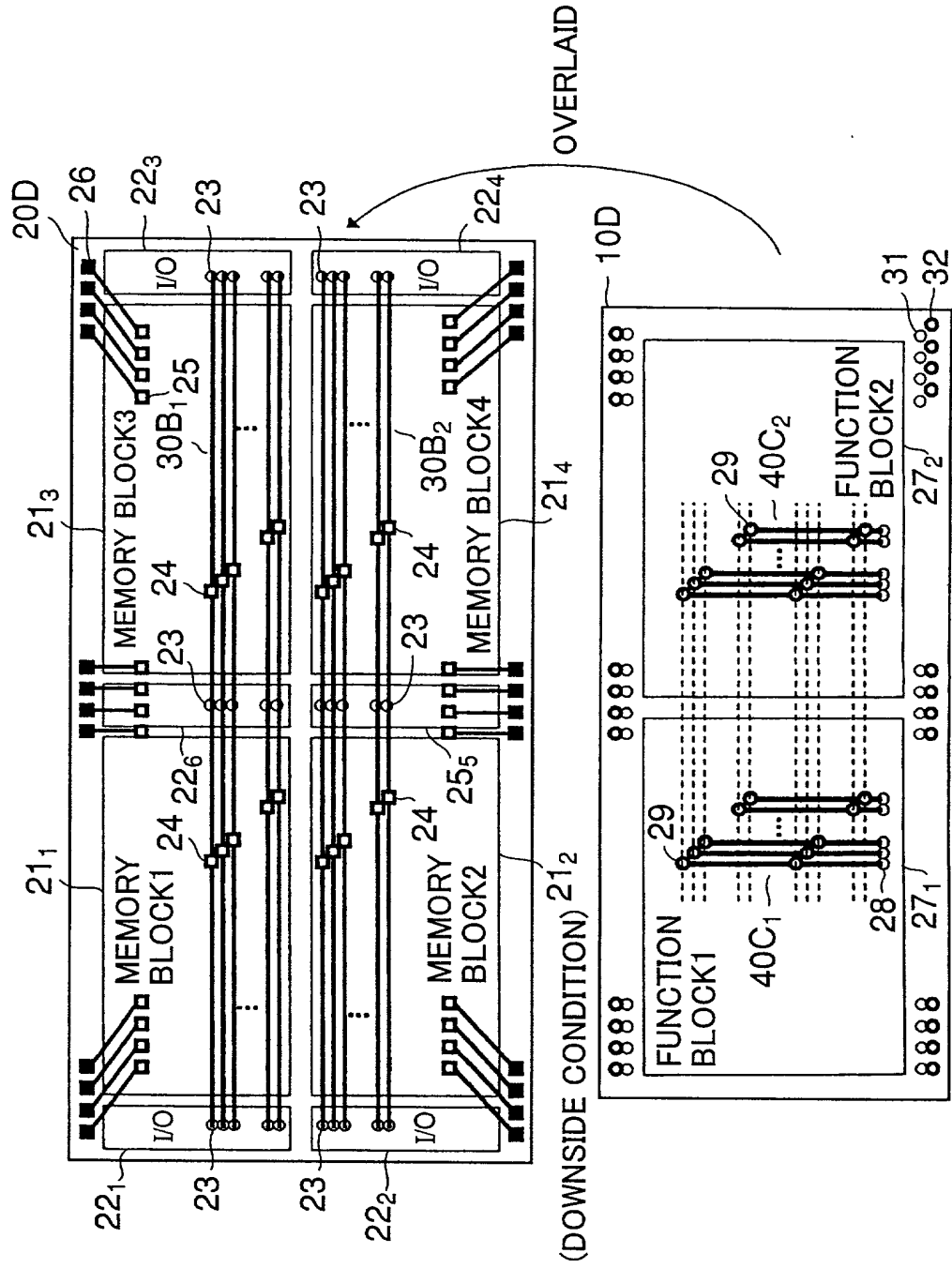


FIG. 19

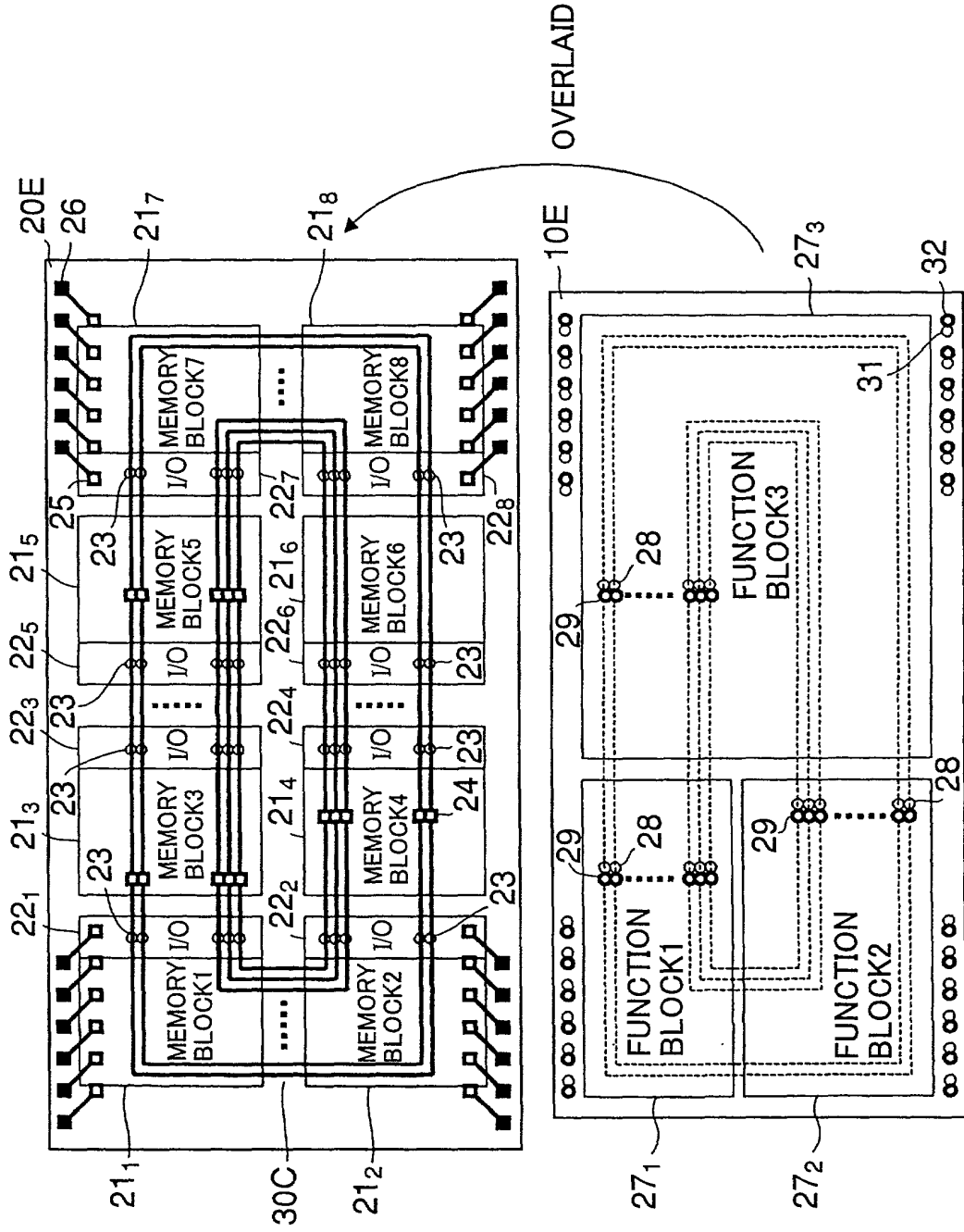


FIG. 20

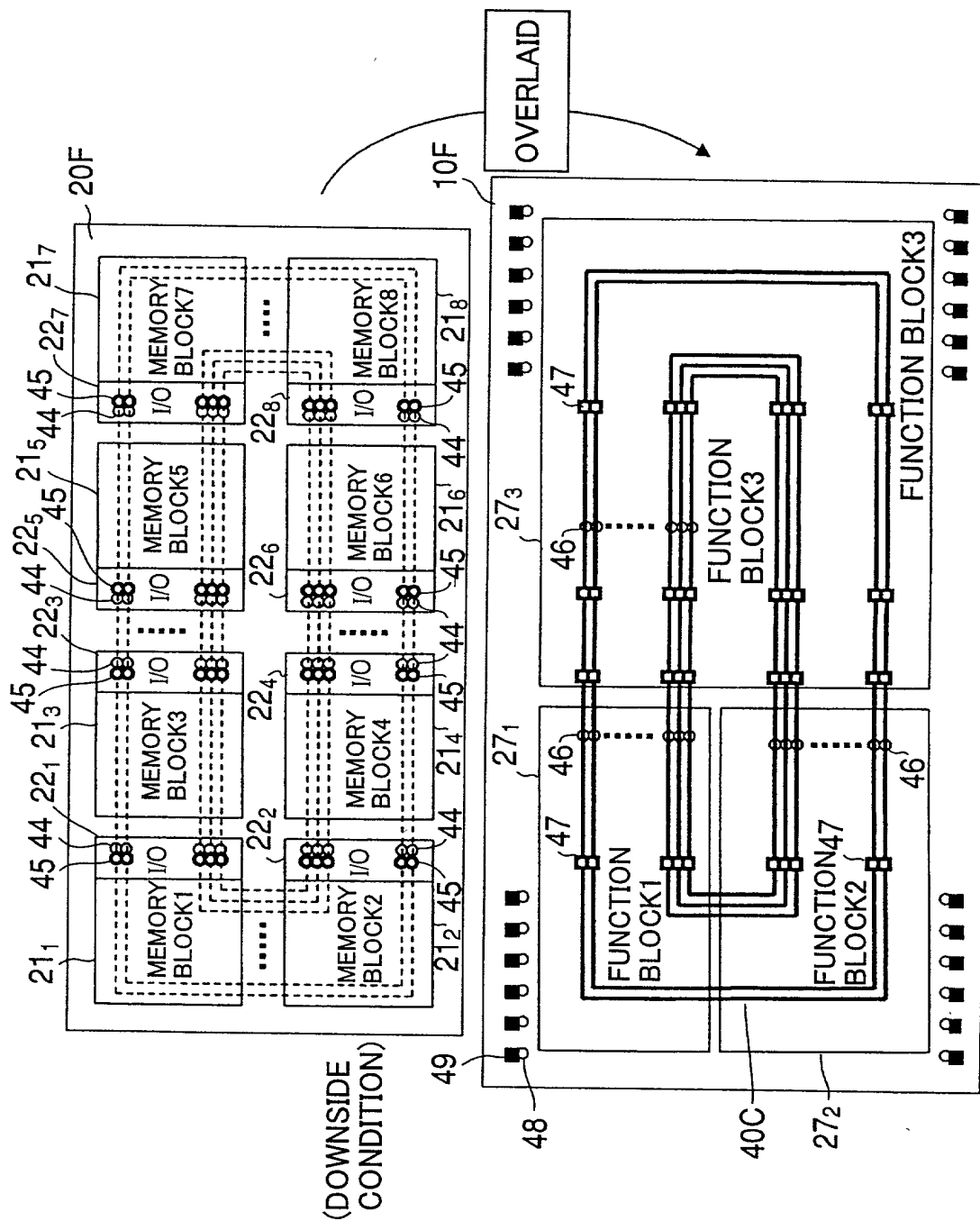


FIG. 21

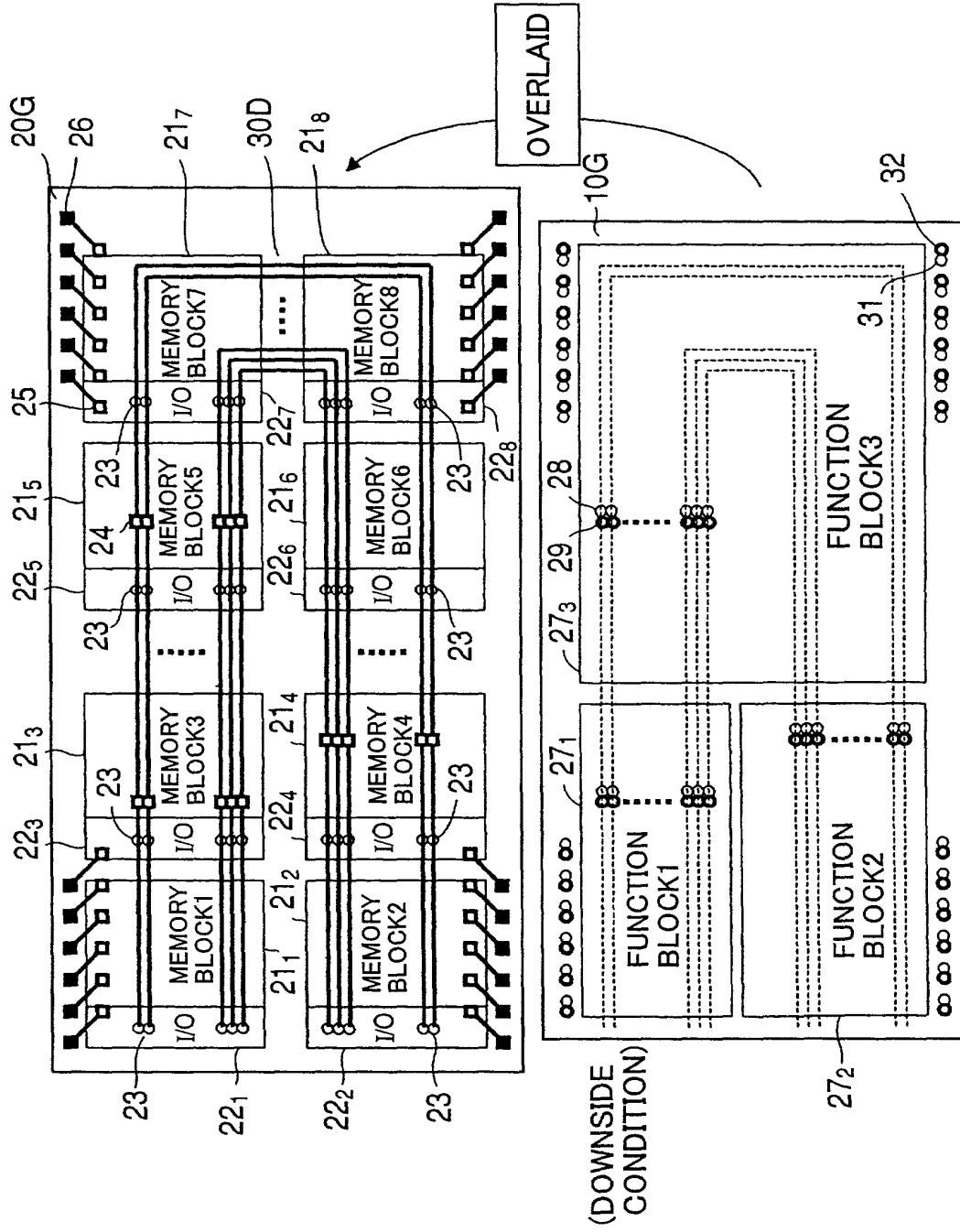


FIG. 22

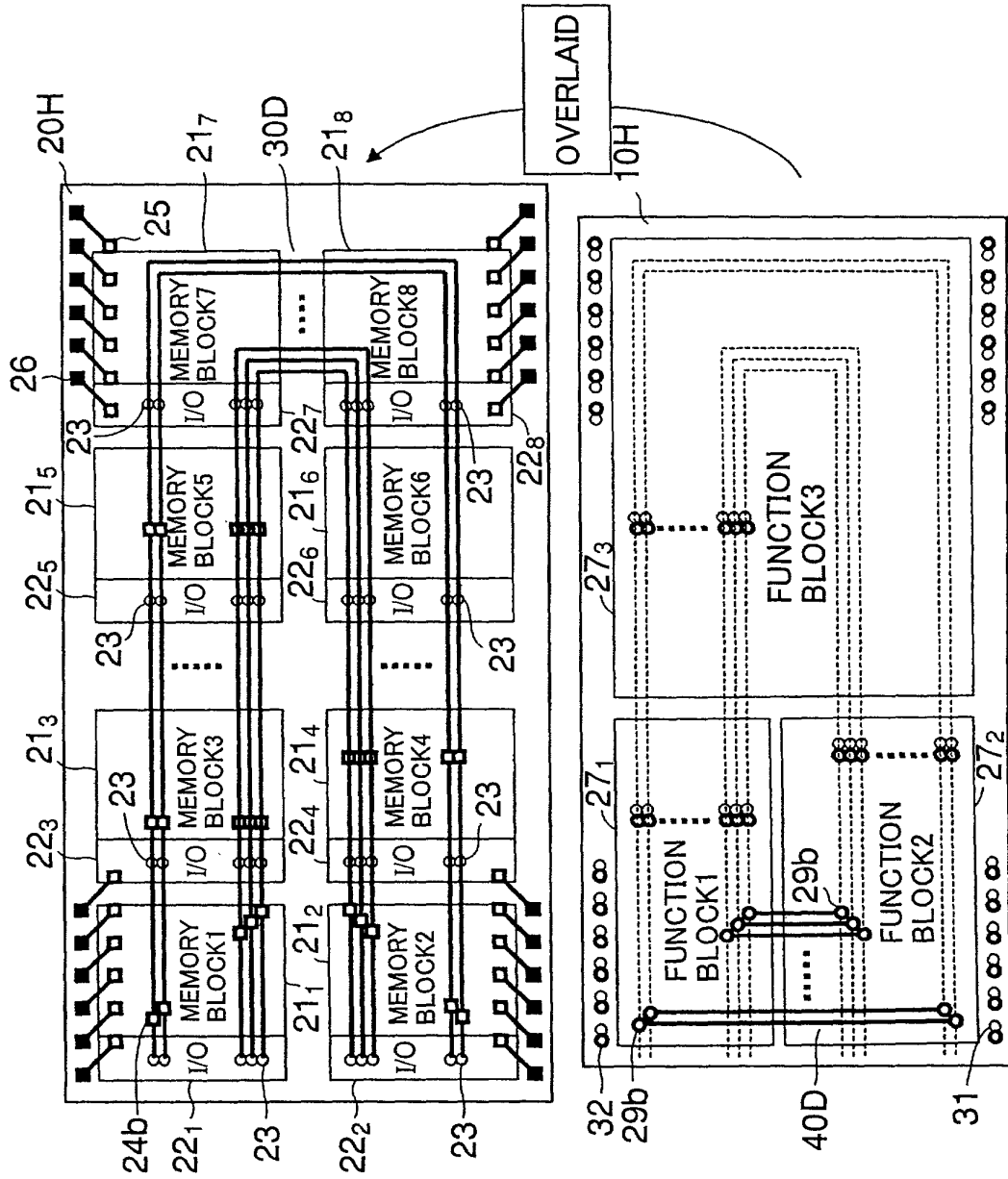


FIG. 23

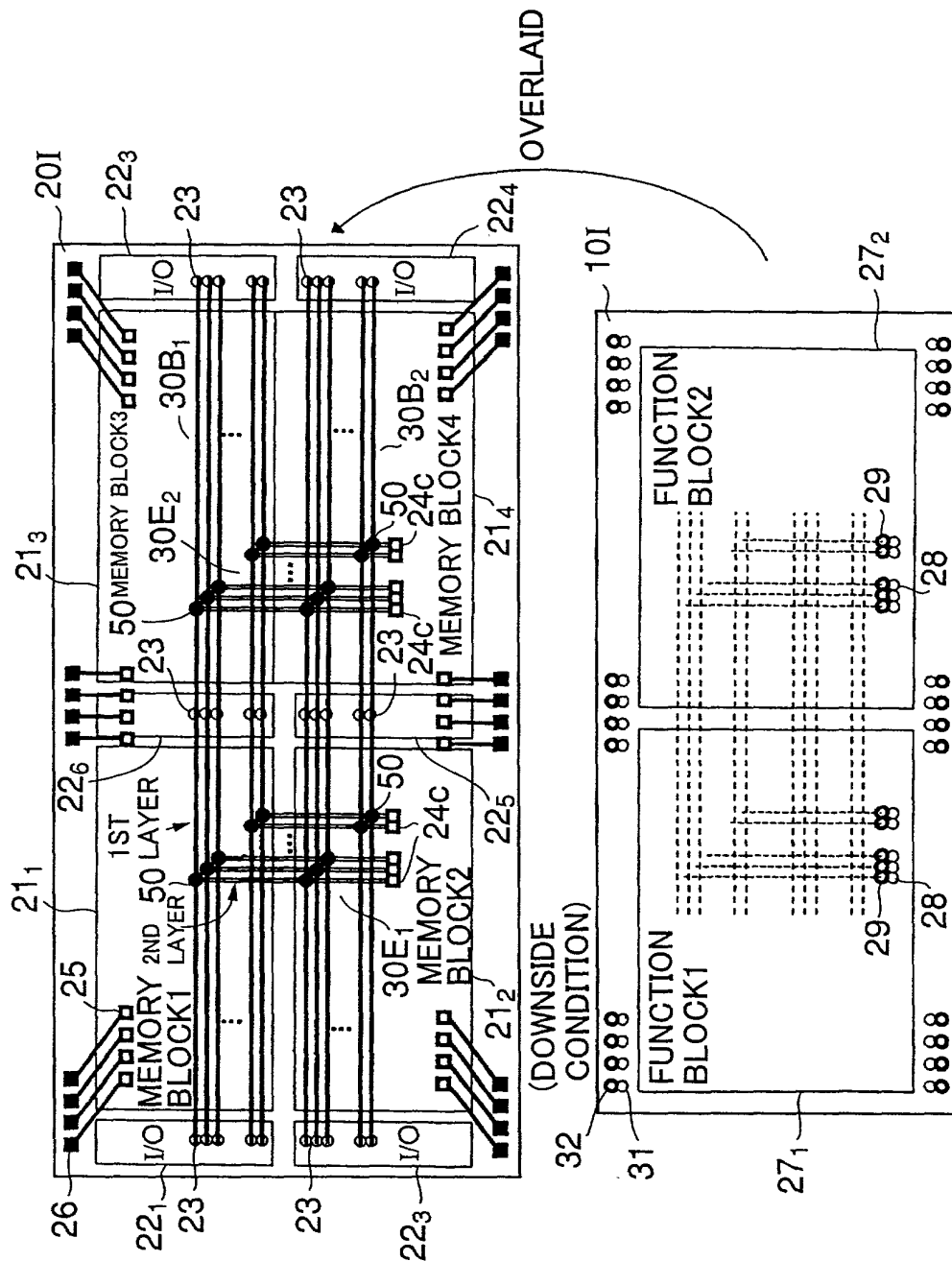


FIG. 24

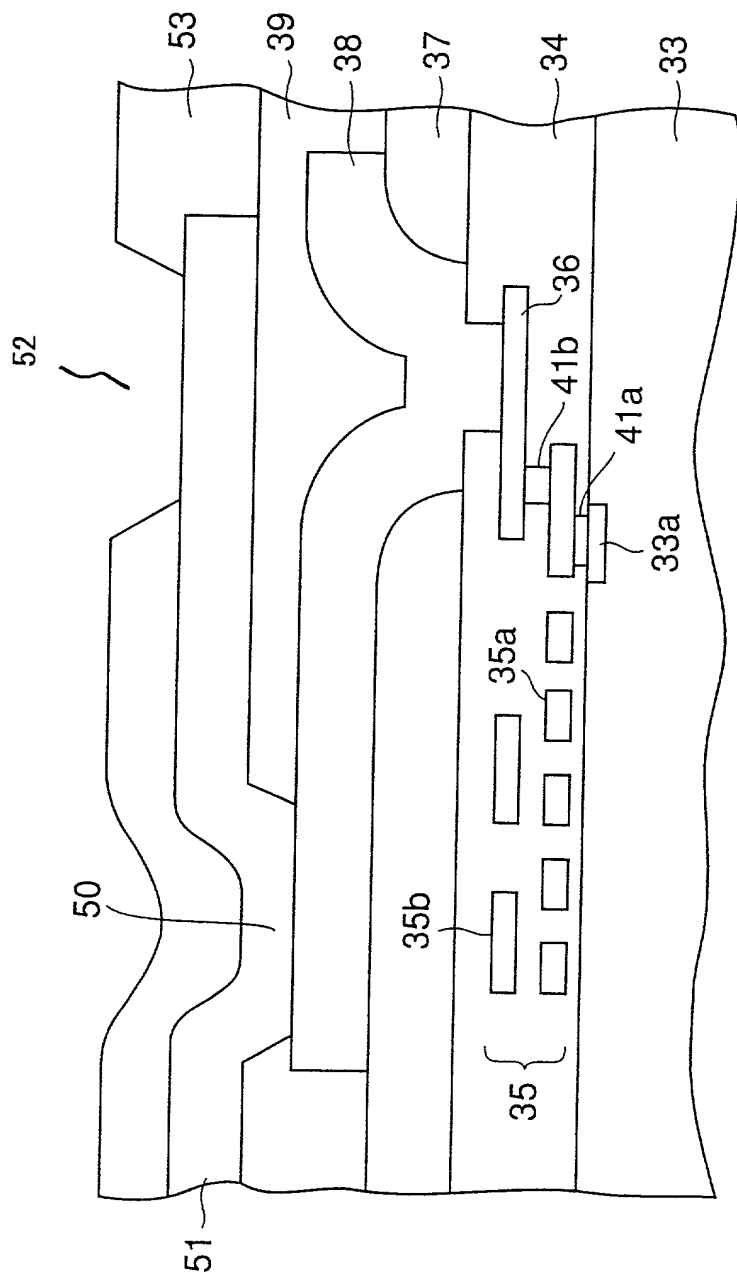


FIG. 25

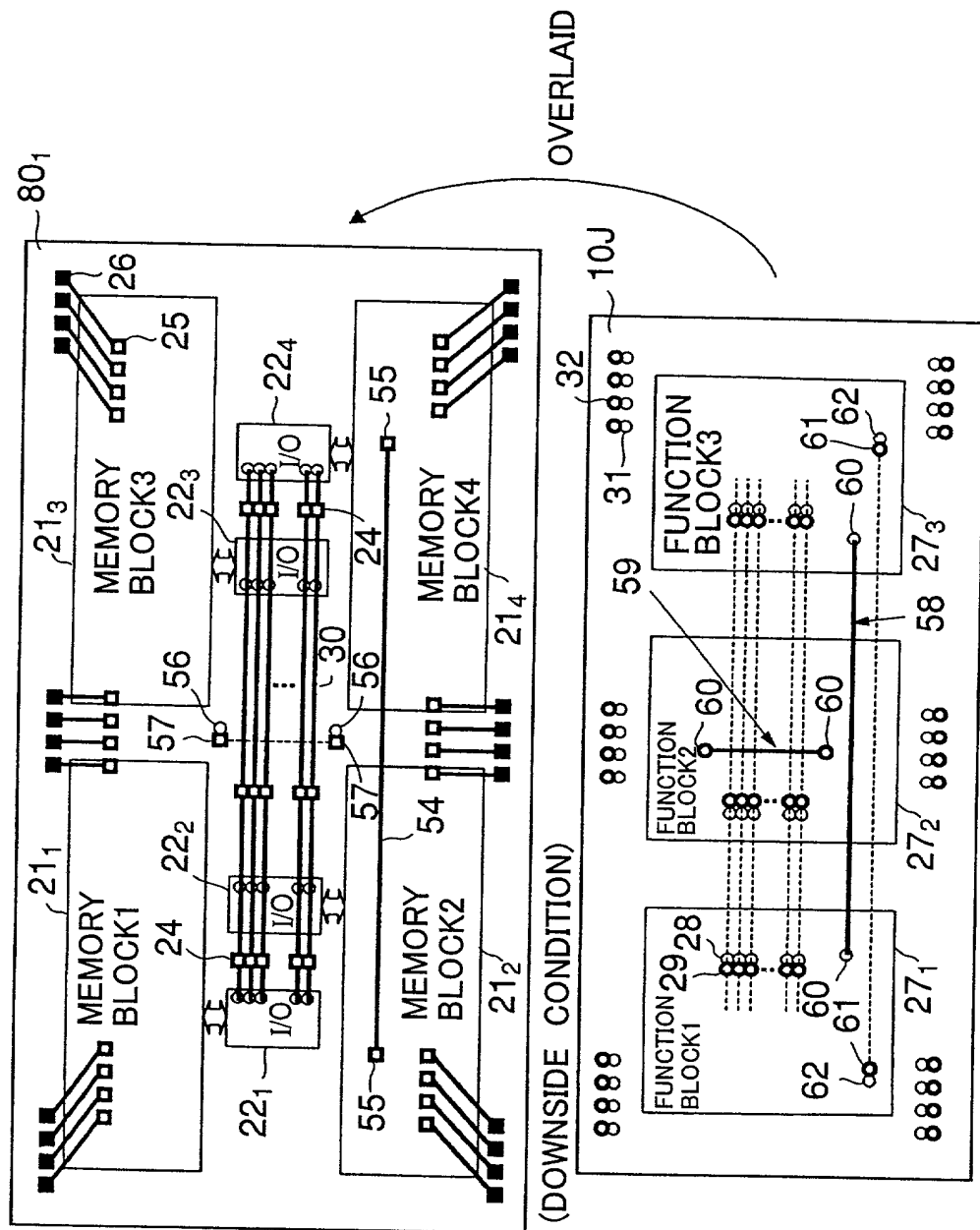


FIG. 26

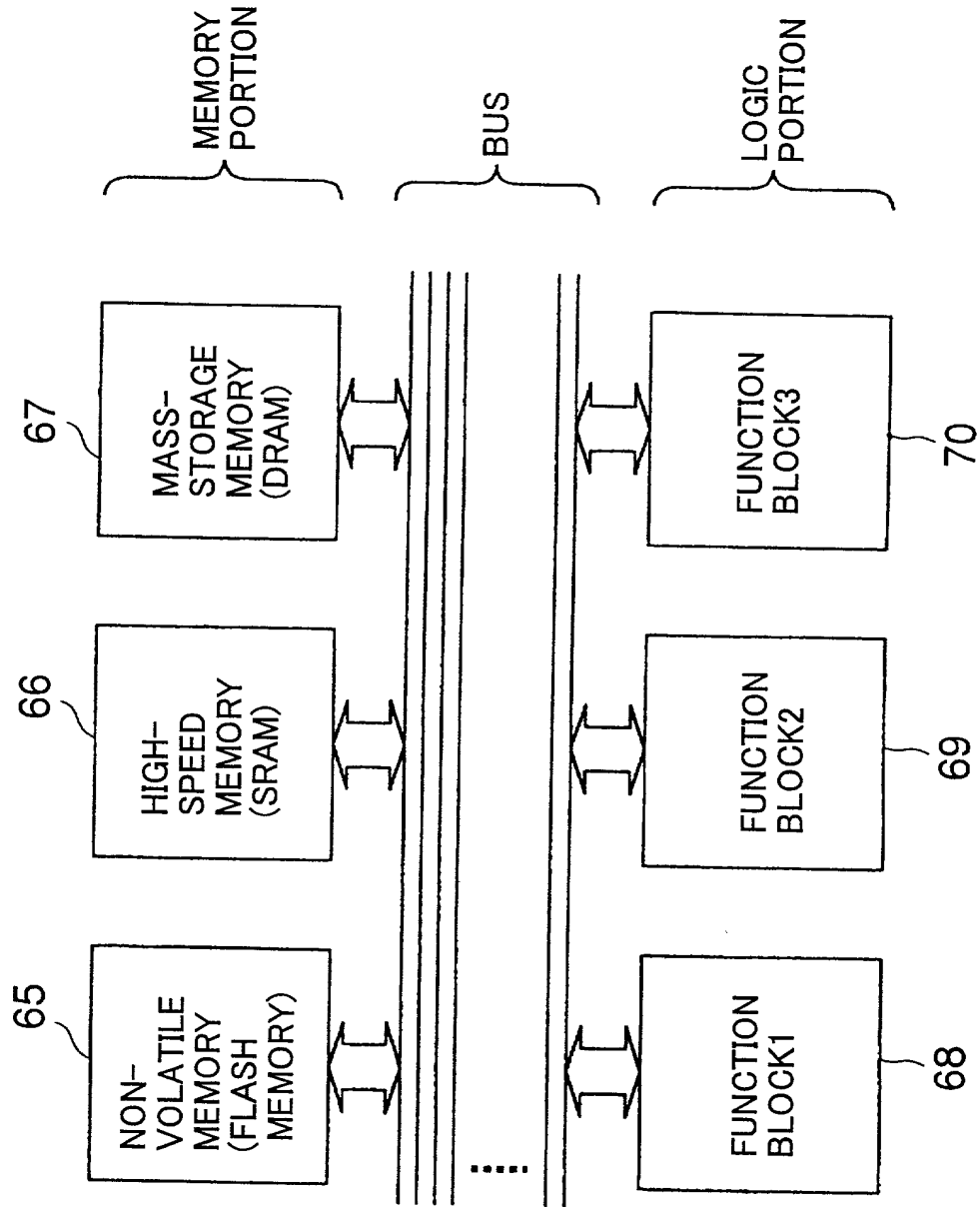


FIG. 27

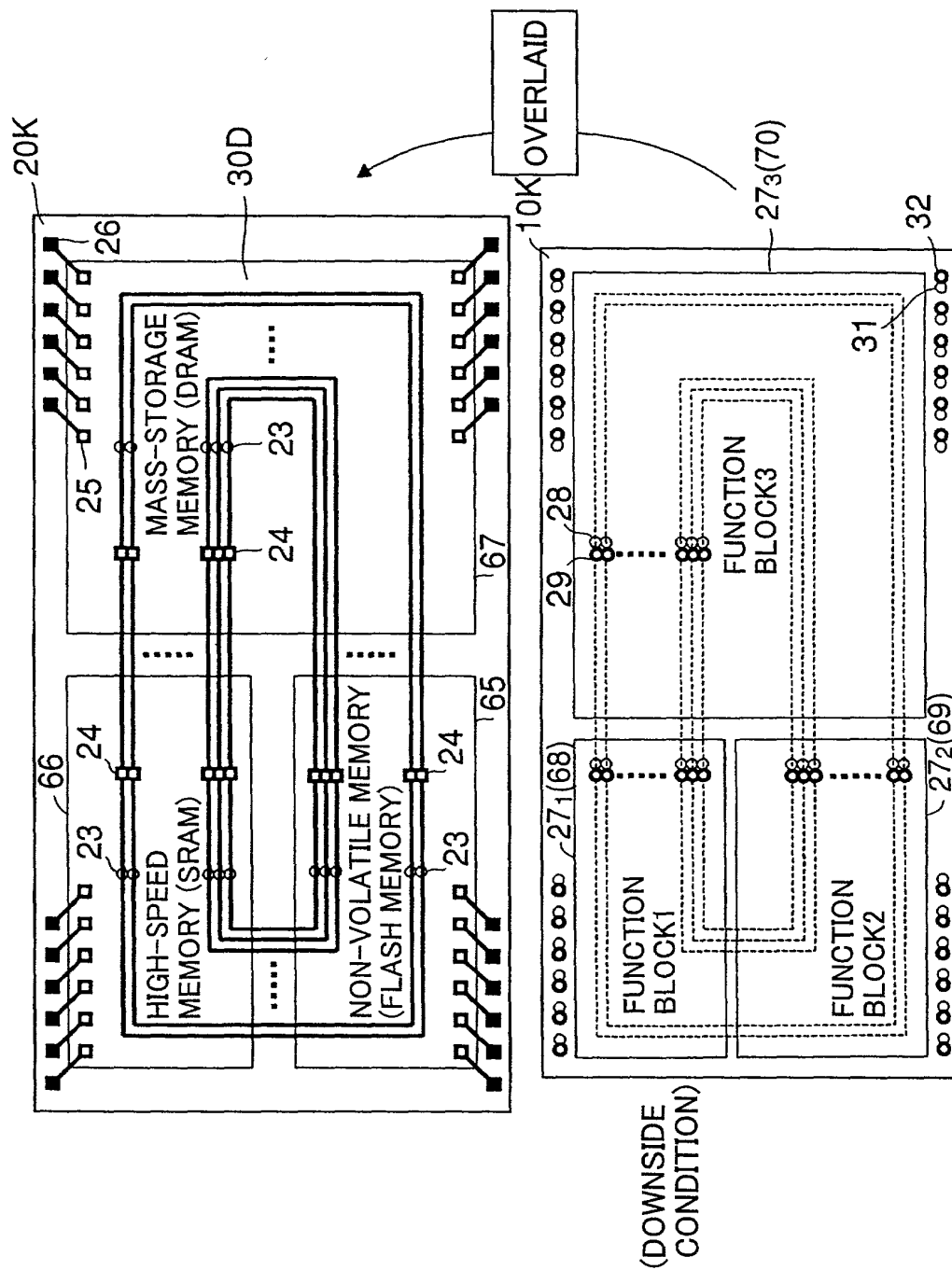


FIG.28

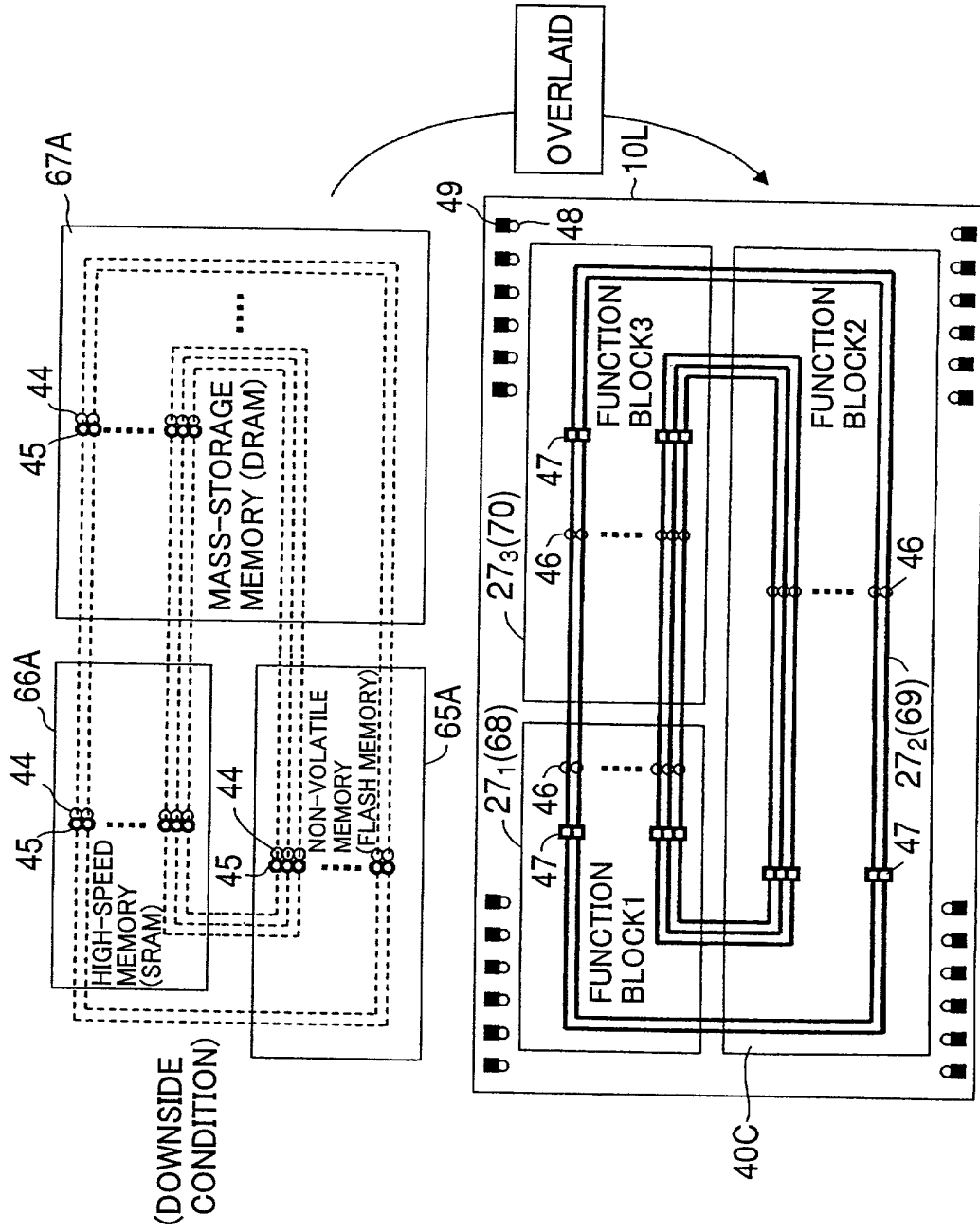


FIG. 29

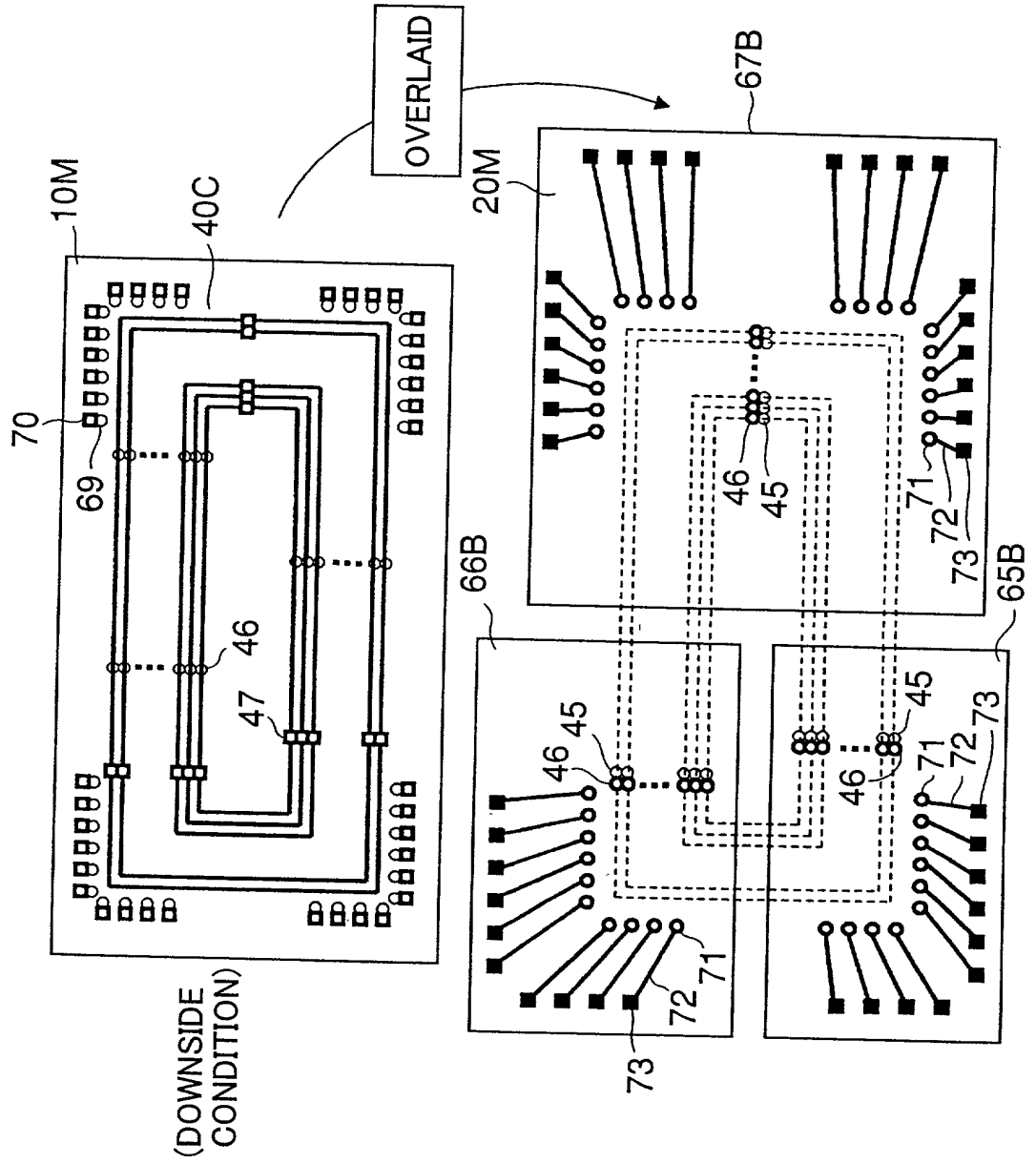


FIG. 30

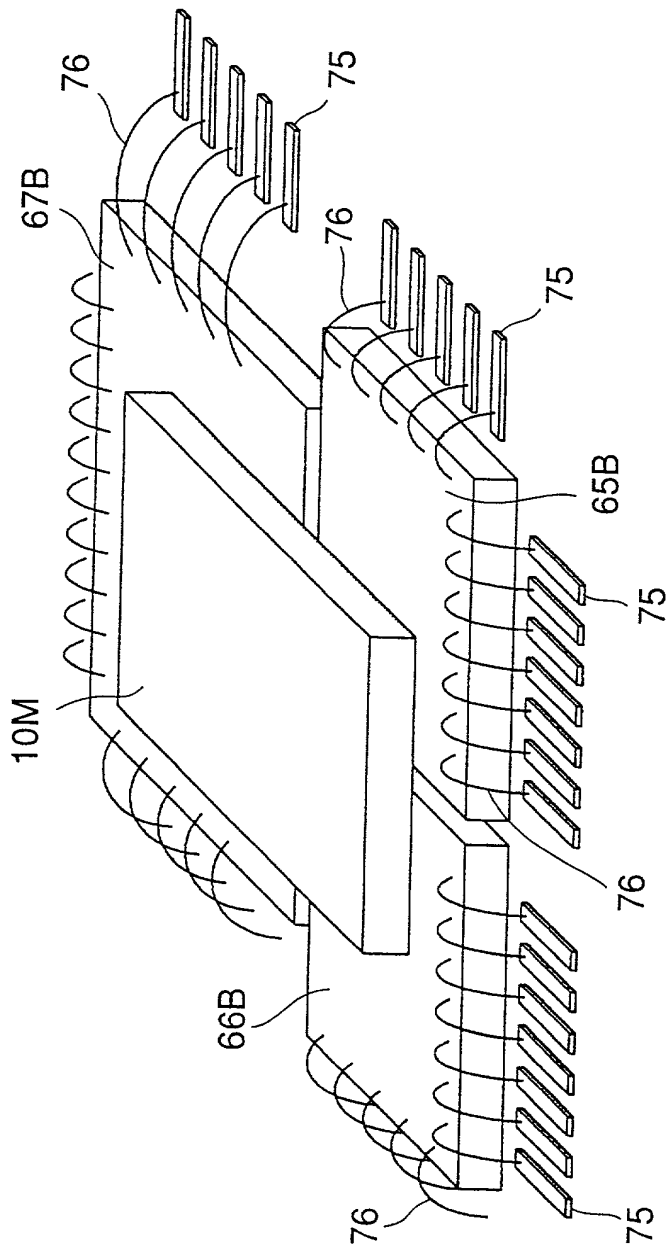


FIG. 31

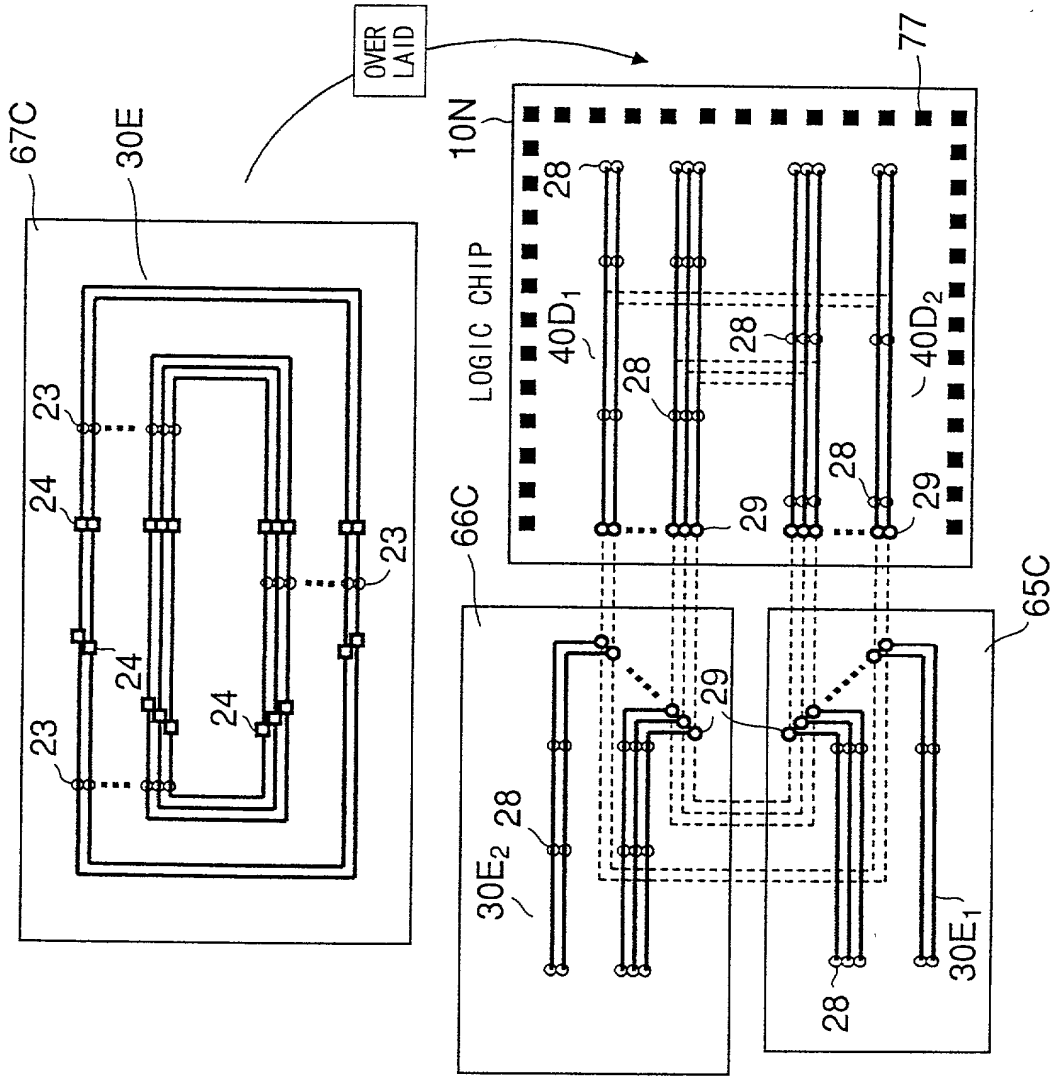


FIG. 32

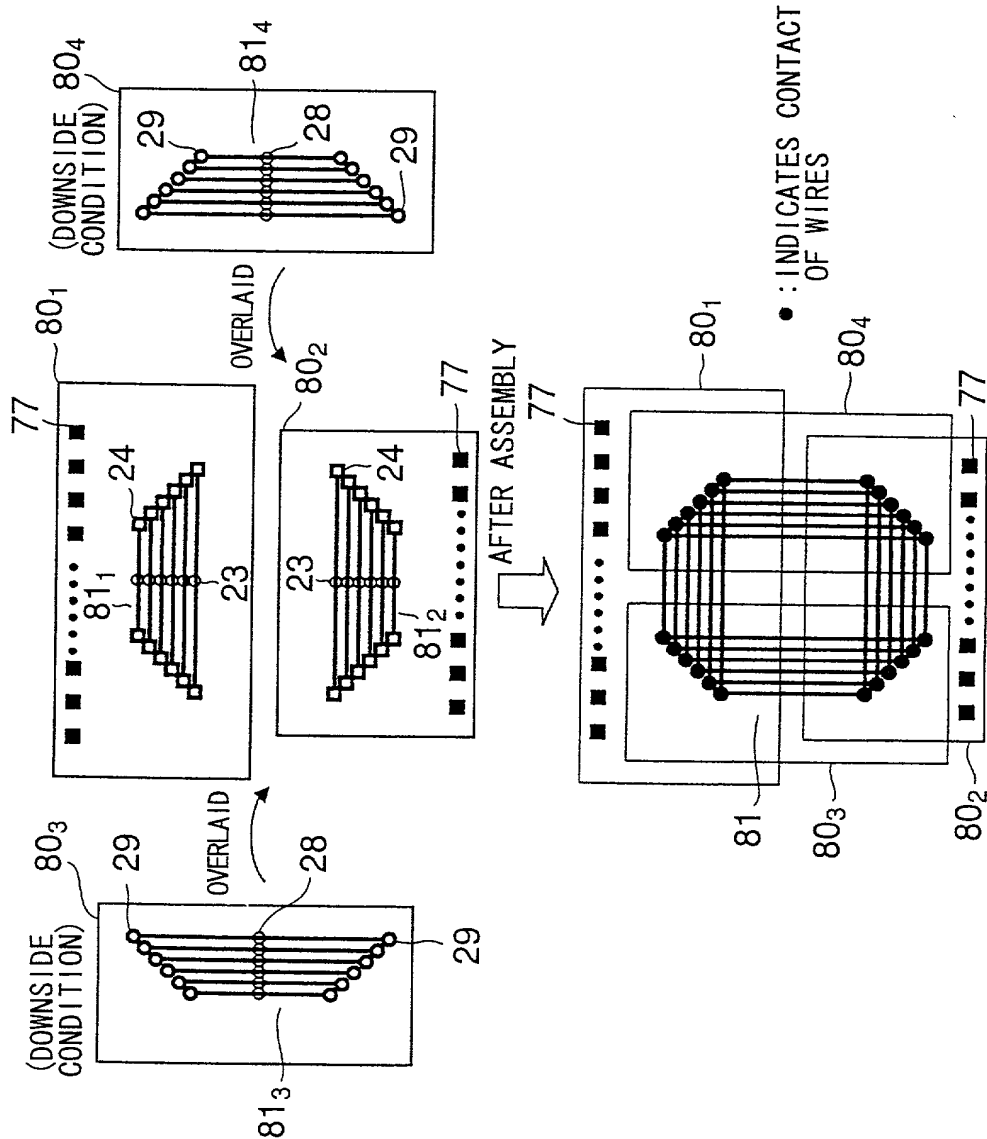


FIG. 33

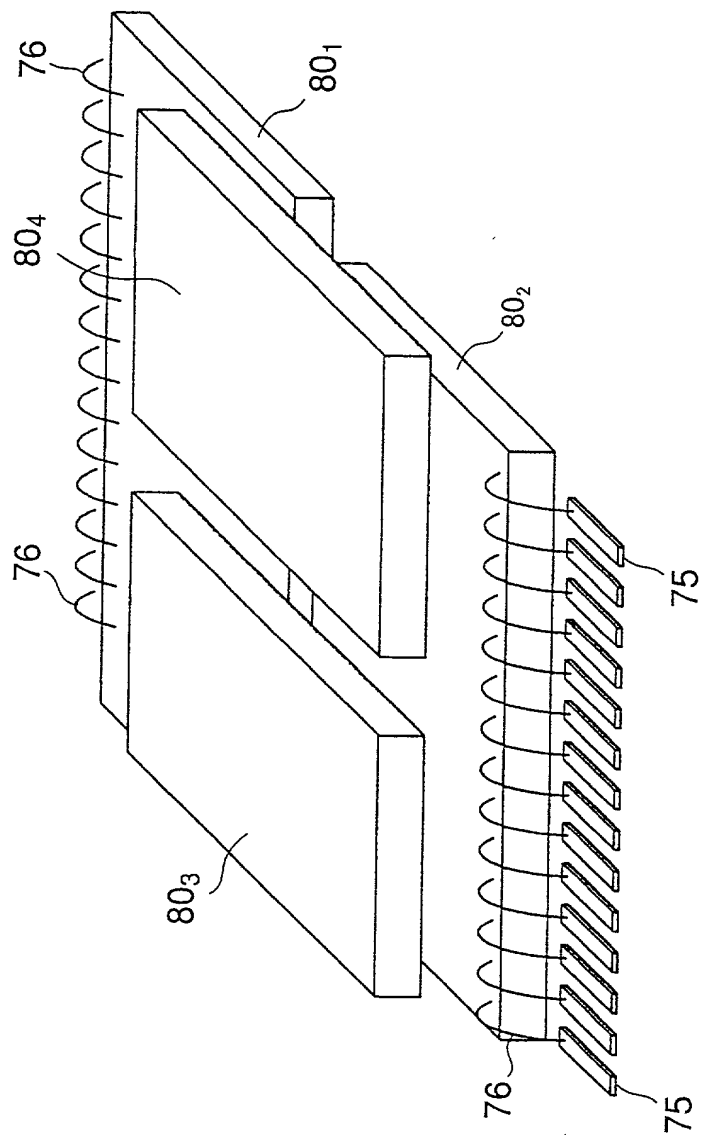
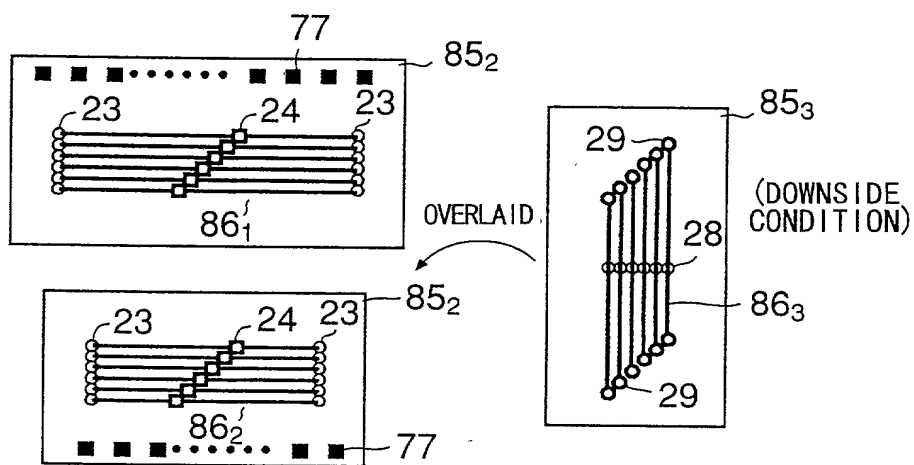


FIG. 34A



AFTER ASSEMBLY

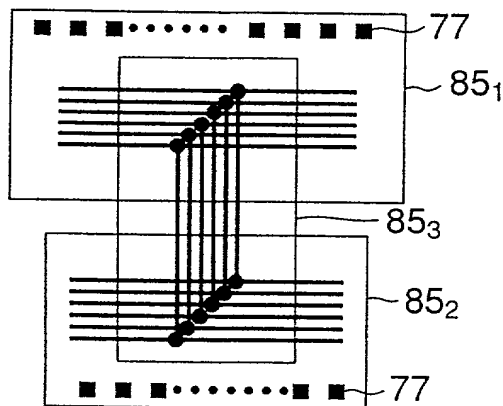


FIG. 34B

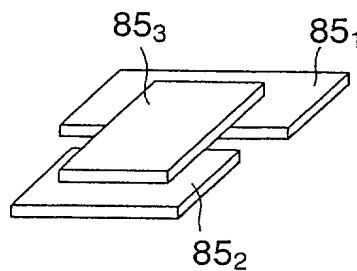


FIG.35

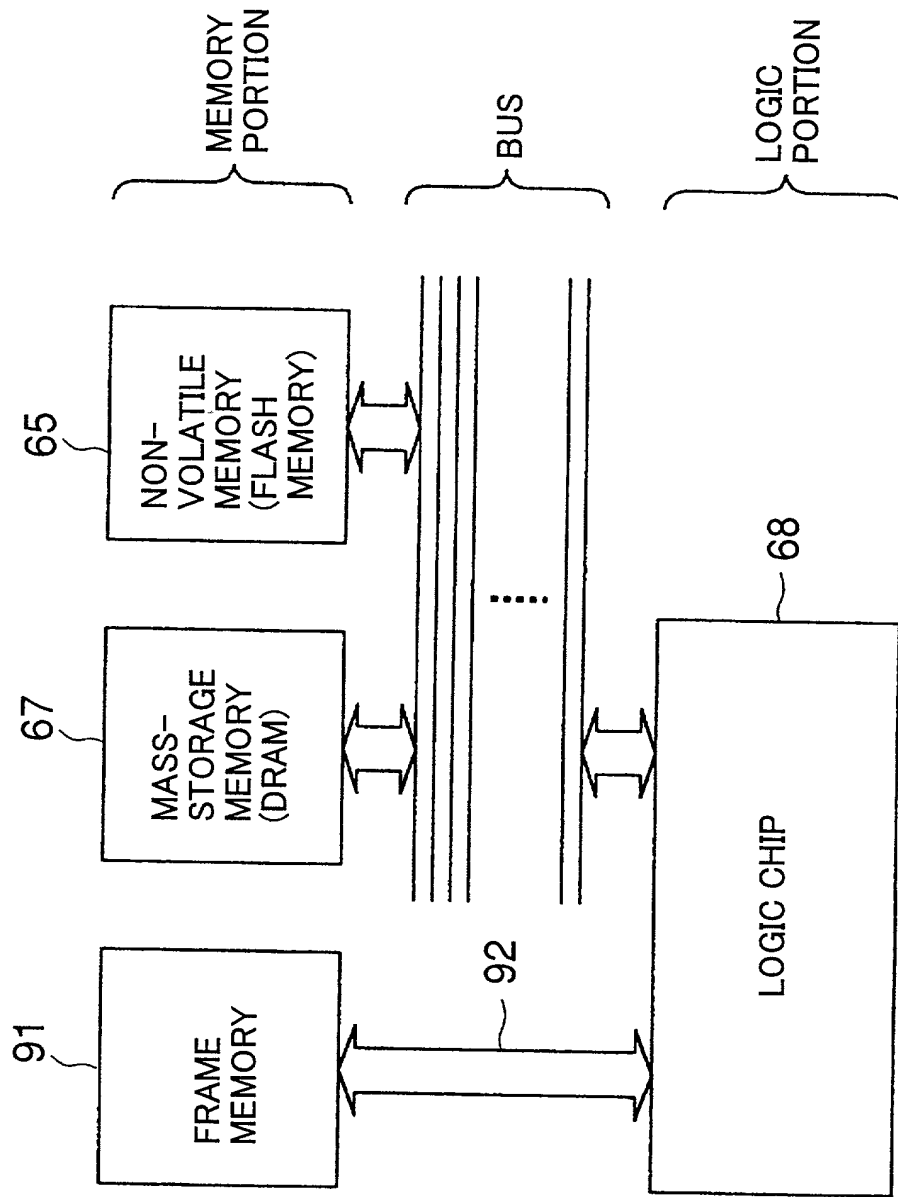


FIG.37

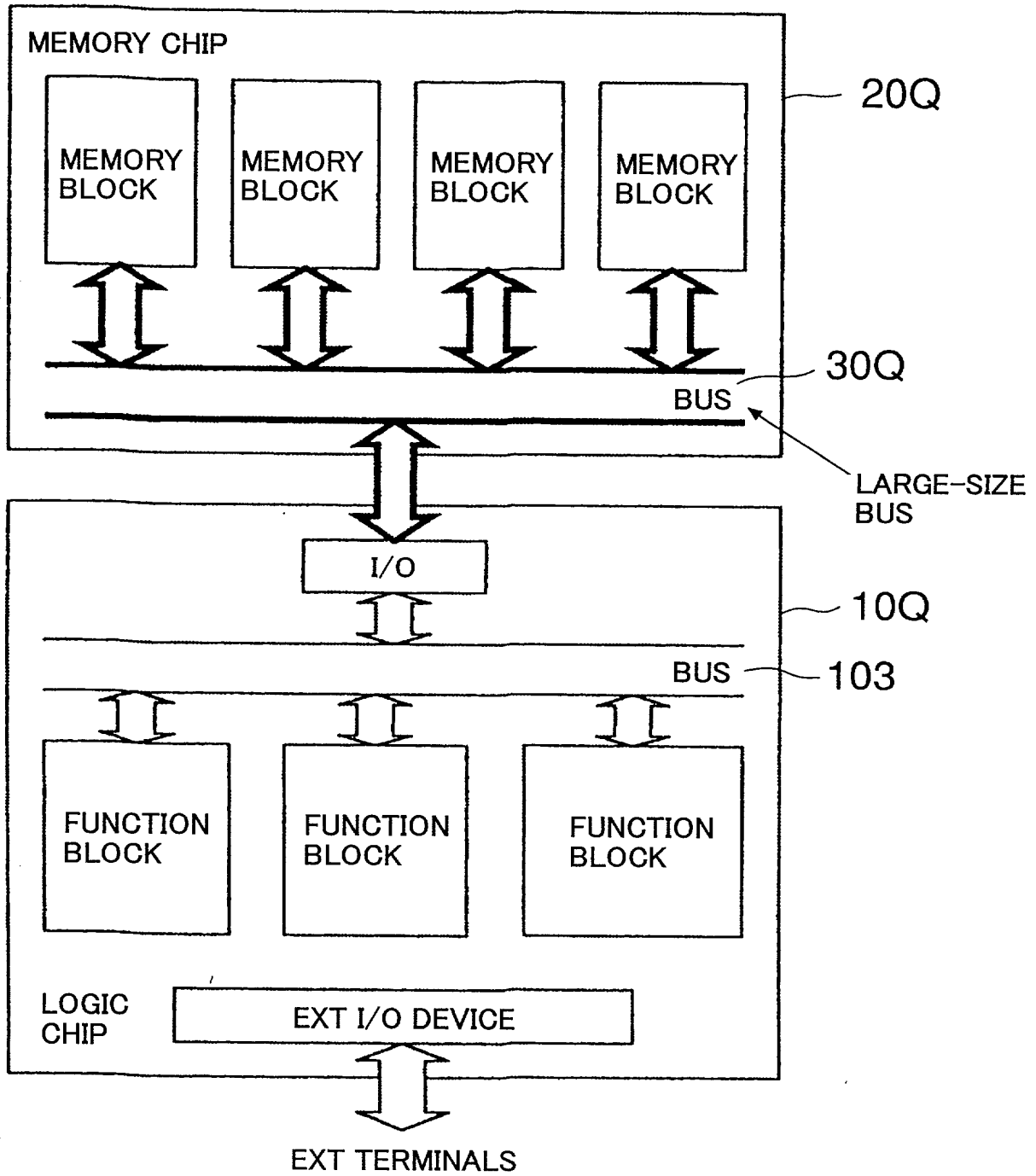


FIG.38

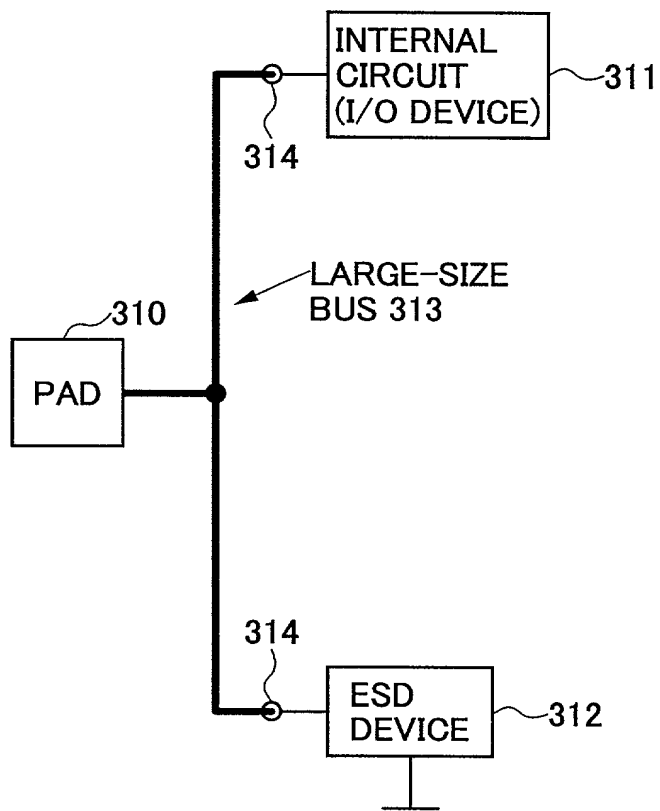


FIG. 39

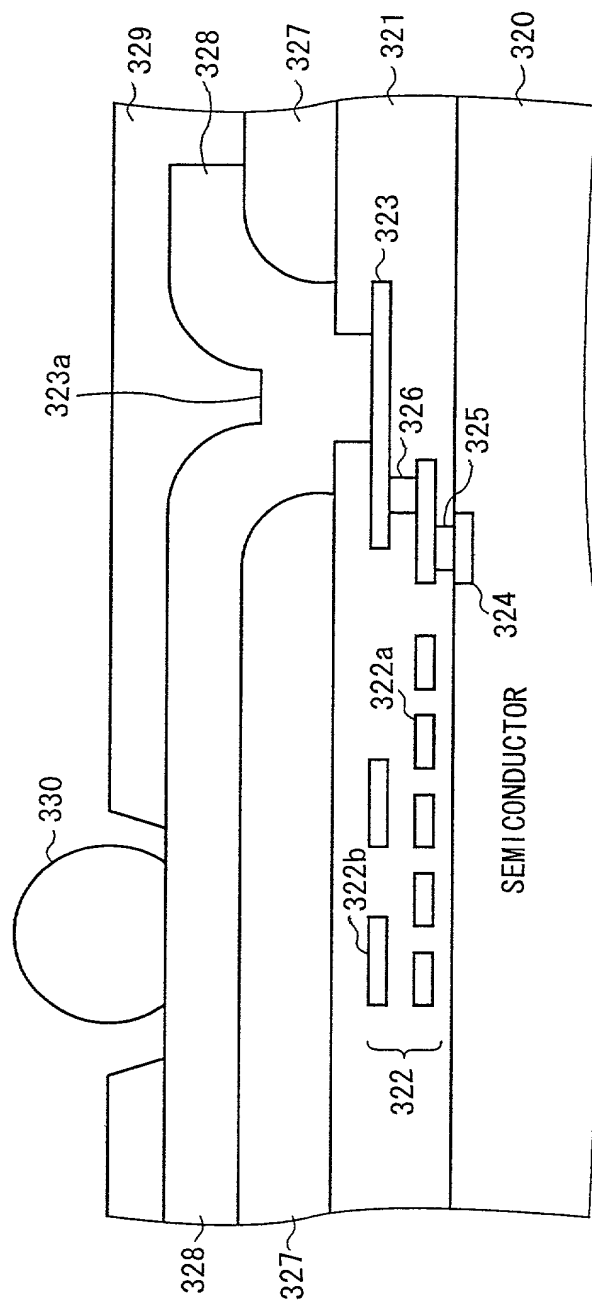


FIG.40

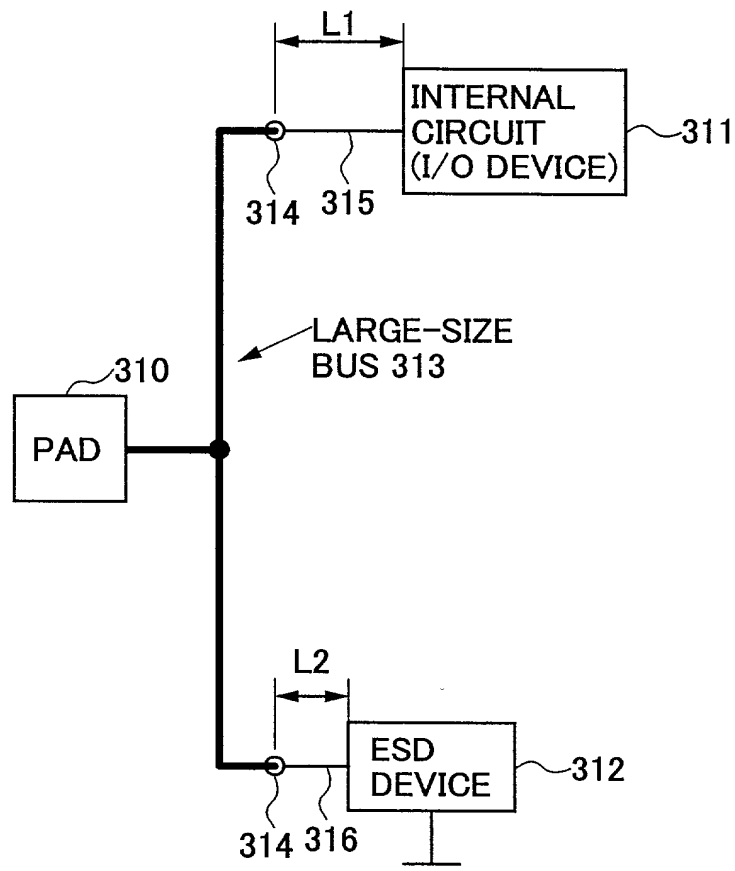


FIG. 41

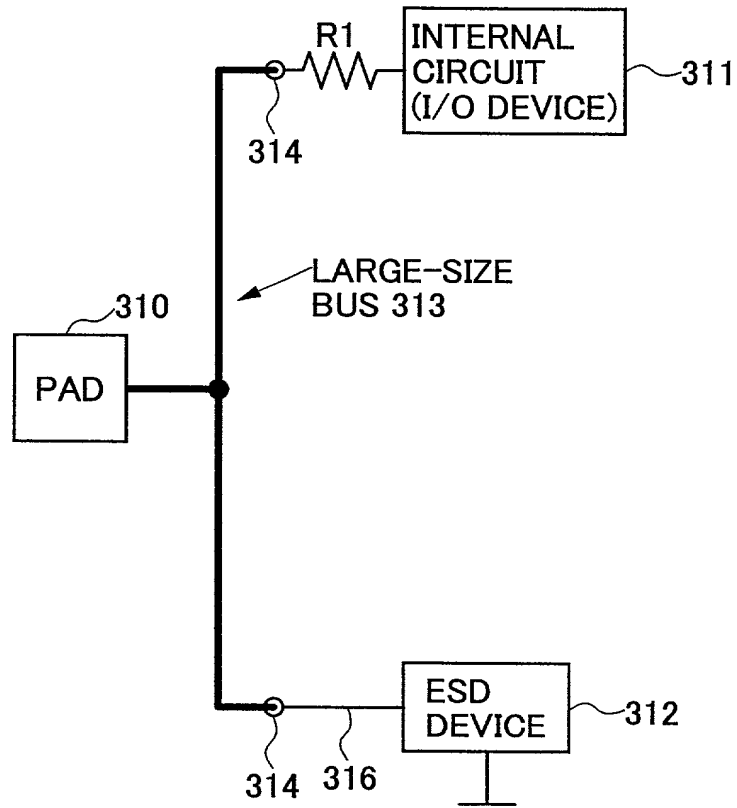


FIG. 42

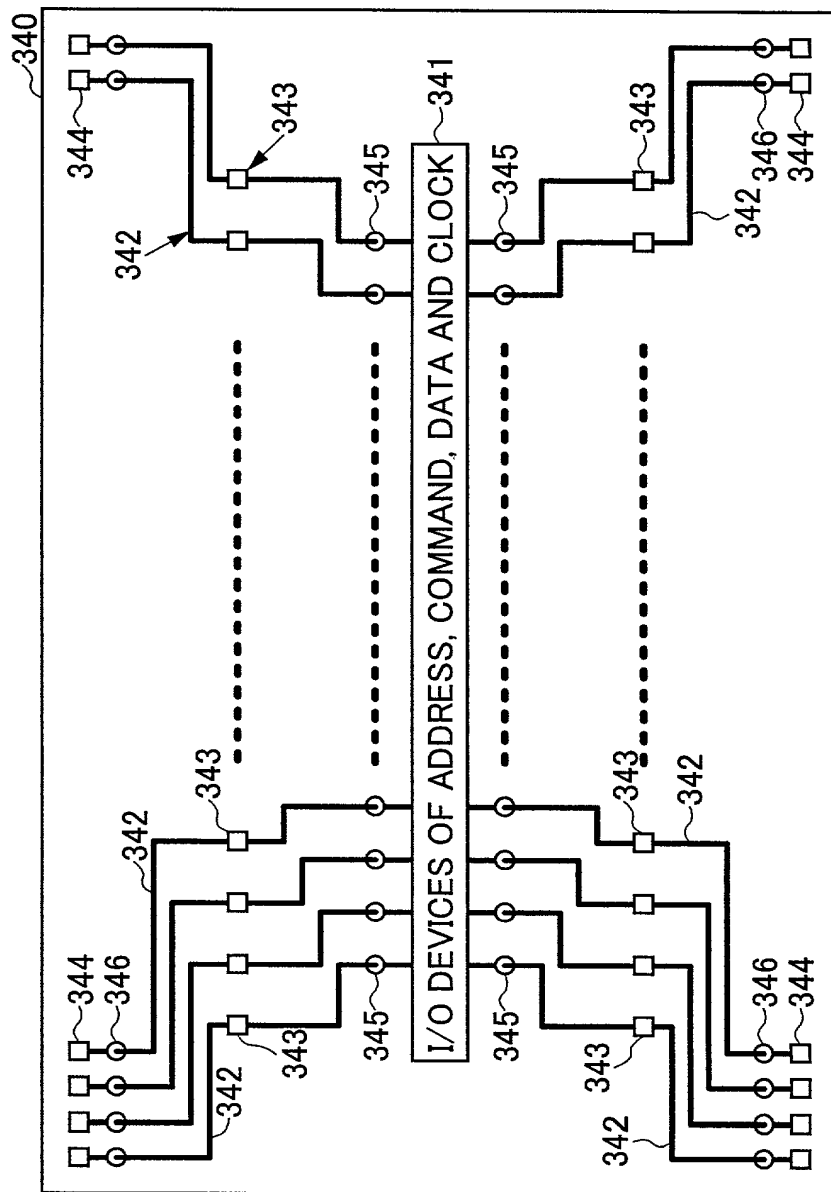


FIG.43

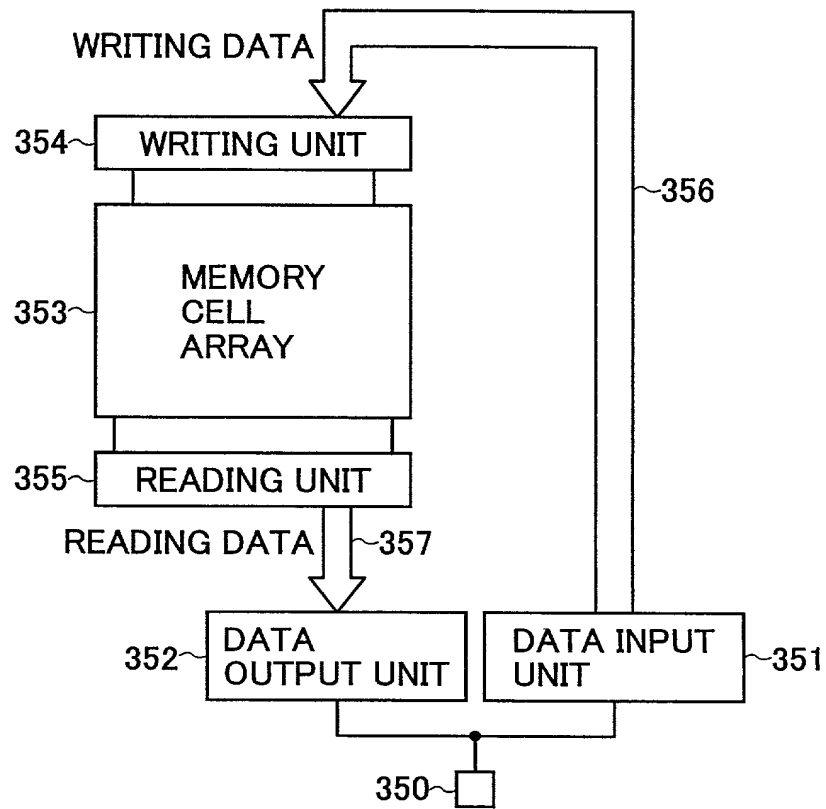


FIG.44A

SINGLE-BIT
SEMICONDUCTOR
APPARATUS

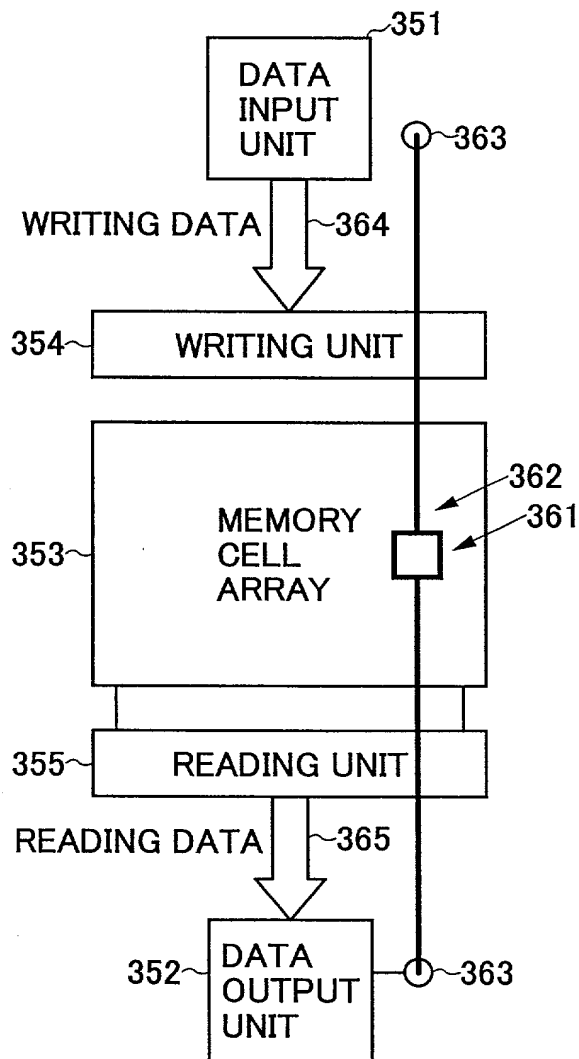


FIG.44B

MULTI-BIT
SEMICONDUCTOR
APPARATUS

